

Unclassified Publications of Lincoln Laboratory

Volume 10

31 December 1984

Lincoln Laboratory

MASSACHUSETTS INSTITUTE OF TECHNOLOGY

LEXINGTON, MASSACHUSETTS



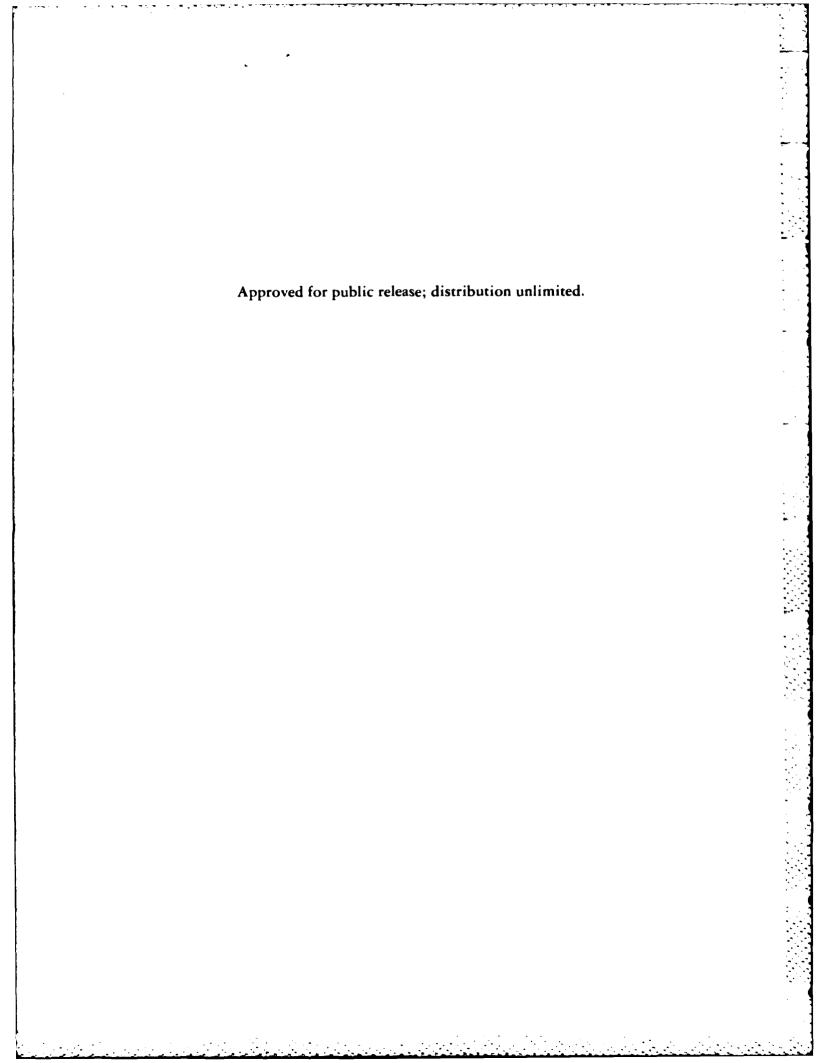
Prepared under Electronic Systems Division Contract F19628-85-C-0002.

UTIC FILE COP

BEST AVAILABLE COPY This document has been approved for public release and sale; its distribution is unlimited.



11 26 028



UNCLASSIFIED PUBLICATIONS OF LINCOLN LABORATORY

VOLUME 10

31 DECEMBER 1984

Requests for information should be directed to:
Lincoln Laboratory
Massachusetts Institute of Technology
Box 73
Lexington, Massachusetts 02173-0073
Attention: Report Distribution Office, L-339

Approved for public release; distribution unlimited.

MASSACHUSETTS INSTITUTE OF TECHNOLOGY

LINCOLN LABORATORY

LEXINGTON, MASSACHUSETTS

The work reported in this document was performed at Lincoln Laboratory, a center for research operated by Massachusetts Institute of Technology, with the support of the Department of the Air Force under Contract F19628-85-C-0002; in some cases, the work was supported under other contracts.

This report may be reproduced to satisfy needs of U.S. Government agencies.

The views and conclusions contained in this document are those of the contractor and should not be interpreted as necessarily representing the official policies, either expressed or implied, of the United States Government.

The ESD Public Affairs Office has reviewed this report, and it is releasable to the National Technical Information Service, where it will be available to the general public, including foreign nationals.

This technical report has been reviewed and is approved for publication.

FOR THE COMMANDER

Thomas J. Alpert, Major, USAF

Chief, ESD Lincoln Laboratory Project Office

Thomas Afreit

FOREWORD

Volume 10 of Unclassified Publications of Lincoln Laboratory lists reports published from 15 December 1983 to 31 December 1984, as well as updated information on earlier publications.

Documents listed herein are generally no longer available from Lincoln Laboratory. Qualified Defense Technical Information Center (DTIC) users may obtain copies through normal DTIC channels. Others may purchase photocopies or microfiche from the U.S. Department of Commerce, National Technical Information Service, Springfield, Virginia 22151. When ordering, the 6-digit AD number should be cited.

4

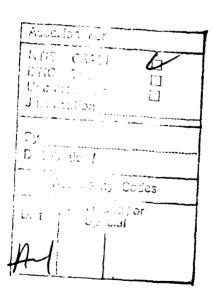




TABLE OF CONTENTS

Foreword	iii
Quarterly Technical Reports	1
Quarterly Technical Summaries	1
Semiannual Technical Summary Reports	3
Miscellaneous Progress Reports	5
Technical Reports	7
Journal Articles	11
Meeting Speeches	23
Author Index	37
Subject Index	45

QUARTERLY TECHNICAL REPORTS

SOLID STATE RESEARCH

DTIC No.			DTIC No.
1983:4	AD-A142991	1984:2	AD-A147640
1984:1	AD-A147429	1984:3	AD-A154783

QUARTERLY TECHNICAL SUMMARIES

WEATHER RADAR STUDIES

30 September 1984

SEMIANNUAL TECHNICAL SUMMARY REPORTS

DISTRIBUTED SENSOR NETWORKS

DTIC No.

DTIC No.

30 September 1983

AD-A146209

31 March 1984

AD-A147638

RESTRUCTURABLE VLSI

31 March 1984

AD-A148145

30 September 1984

AD-A152340

DARPA/TTO PROGRAM IR BINARY OPTICS

30 June 1984

AD-A152196

WIDEBAND INTEGRATED VOICE/DATA TECHNOLOGY

31 March 1984

AD-A146054

30 September 1984

AD-A152329

MISCELLANEOUS PROGRESS REPORTS

DEFENSE SWITCHED NETWORK TECHNOLOGY

DTIC No. DTIC No.

30 September 1982 AD-A140609

GalnAsP LASERS

7 August 1984 AD-A146551

InP MATERIALS

30 September 1984 AD-A152341

SUPERCONDUCTIVE SIGNAL-PROCESSING DEVICES

30 November 1984 AD-A152703

UNCLASSIFIED PUBLICATIONS OF LINCOLN LABORATORY (Previous Volumes)

15 September 1966	AD-803845	15 December 1977	AD-A062413
15 September 1969	AD-863031	15 December 1979	AD-A101092
15 September 1971	AD-734038	15 December 1981	AD-A129036
15 December 1973	AD-778085	15 December 1983	AD-A144354
15 December 1975	AD-A028523		

TECHNICAL REPORTS

TR No.				DTIC No.
618	Angles-Only, Ground-Based, Initial Orbit Determination	Taff, L.G. Randall, P.M.S. Stansfield, S.A.	14 May 1984	ADA142994
634	Expected Energy Method for Electro-Optical SNR Calculations	Mayer, G.J.	2 Feb. 1984	ADA139984
654	Performance of Bayes-Optimal Angle-of-Arrival Estimators	White, F.M.	13 Aug. 1984	ADA146594
662	Electromagnetic Scattering by Arbitrarily Shaped Reflectors: Subreflector Efficiency	Dion, A.R. Muresan, I.V.	31 Oct. 1984	ADA149224
667	Spatial Acquisition Algorithms and Systems for Intersatellite Optical Communication Links	Van Hove, P. Chan, V.W.S.	27 Nov. 1984	ADA150794
669	Electronic Properties of Grain Boundaries in GaAs: A Study of Oriented Bicrystals Prepared by Epitaxial Lateral Overgrowth	Salerno, J.P. Fan, J.C.C. McClelland, R.W. Vohl, P. Mavroides, J.G. Bozler, C.O.	10 May 1984	ADA144358
671	Evaluation of the Comprehension of Non-Continuous, Sped-Up Vocoded Speech: A Strategy for Coping with Fading HF Channels	Lynch, J.T. Gold, B. Tierney, J. Bowers, C.J.	5 Jan. 1984	ADA138650
676	The Lincoln Low-Rate Vocoder: A 1200/2400 bps LPC-10 Voice Terminal	Paul, D.B.	21 Mar. 1984	ADA141291
677	Optimum Leakage Attacks on Combined Area-Terminal Defense Systems	Weiner, S.D.	2 Feb. 1984	ADA139940
680	The Discrimination of Pitch in Pulse Trains and Speech	Mack, M.A. Gold, B.	12 Apr. 1984	ADA142996

Technical Reports

68	81 Switch Features that B			DTIC No.
	Switch Features that Permit a Outboard Processor to Contro Routing and Preemption	Lippmann, R.P. Heggestad, H.M Berger, R.	6 July 1984 1.	ADA146193
68	The Lincoln Laboratory- Aerospace Medical Research Laboratory Digital Speech Test Facility	Tierney, J. Schecter, H.	25 May 1984	ADA144303
684	4 The Limp Flywheel	Lerner, R.M.		
685	VLSI Self-Testing Using Exhaustive Bit Patterns	Dervisoglu, B.I.	13 June 1984 31 May 1984	ADA146034 ADA144299
686		Dunn, K-P.	4 June 1984	ADA144377
688	Anisotropy and Relaxation Effects of CO ²⁺ Ions in LiTi Ferrite	Dionne, G.F.	15 Aug. 1984	ADA146550
689	The ML Method for Frequency Estimation of Real Sinusoids in Noise	Tsai, M.J.	27 July 1984	ADA146053
691	Speech Enhancement Using Multiple Microphones	Harrison, W.A.	15 Nov. 1984	ADA149223
94	Filtering and Prediction Performance for a Class of Systems with Uncertain Parameters	Chang, C-B. Dunn, K-P.	27 July 1984	ADA146145
99	Tristatic Tracking Filter Used by the Multistatic Measurement System	Smith, M.L.	12 Sep. 1984	ADA146885
	Correction for Atmospheric Refraction in an Airborne, Operational Environment	Sorvari, J.M.	31 Aug. 1984 A	DA146552
5 9	Statistical Signal Models and Algorithms for Image Analysis	Quatieri, T.F. Dudgeon, D.E. Therrien, C.W.	25 Oct. 1984 A	DA149225
7 S B	Speech Analysis Synthesis Based on Perception	Andon	5 Nov. 1984 A	DA151320

Technical Reports

TR No.				DTIC No.
709	Scattering from Conducting Bodies of Revolution: Behavior of the Integral Equations Near Singular Points of Their Kernels	Kelly, E.J.	14 Nov. 1984	ADA149226
712	Comparative Architectures for a Multiple Function Speech Processor	Singer, E.	18 Dec. 1984	ADA150873

JOURNAL ARTICLES

JA No.			
5297	Application of State Estimation to Target Tracking	Chang, C-B. Tabaczynski, J.A	IEEE Trans. Autom. Control, Vol. AC-29, No. 2, February 1984, pp. 98-109
5356	Maximum Likelihood Spectral Estimation and Its Application to Narrow-Band Speech Coding	McAulay, R.J.	IEEE Trans. Acoust., Speech, Signal Process., Vol. ASSP-32, No. 2, April 1984, pp. 243-251 ADA147582
5399	Automated Foucault Test for Focus Sensing	Kocher, D.G.	Appl. Opt., Vol. 22, No. 12, 15 June 1983, pp. 1887-1892
5425	Properties of Separable Co- variance Matrices and Their Associated Gaussian Random Processes	Therrien, C.W. Fukunaga, K.	IEEE Trans. Pat. Anal. Mach. Int., Vol. PAMI-6, No. 5, September 1984, pp. 652-656
5429	20 GHz Optical Waveguide Sampler	Molter-Orr, L.A. Haus, H.A. Leonberger, F.J.	IEEE J. Quantum Electron., Vol. QE-19, No. 12, December 1983, pp. 1877-1884
5452	Optimal Searches for Asteroids	Taff, L.G.	Icarus, Vol. 57, No. 2, February 1984, pp. 259-266
5454	An Overview of Packet- Switching Communications	Heggestad, H.M.	IEEE Commun. Mag., Vol. 22, No. 4, April 1984, pp. 24-31 ADA147934
5464	Image Enhancement for the Visually Impaired	Peli, E. Peli, T.	Opt. Eng., Vol. 23, No. 1, January/February 1984, pp. 47-51
5465	Electron Devices on Piezo- electric Semiconductors: A Device Model	Withers, R.S.	IEEE Trans. Sonics Ultrason., Vol. SU-31, No. 2, March 1984, pp. 117-123

JA No.

5468	Effect of Nitridation of Silicon Dioxide on Its Infrared Spectrum	Naiman, M.L. Kirk, C.T., Jr. Aucoin, R.J. Terry, F.L. Wyatt, P.W. Senturia, S.D.	J. Electrochem. Soc., Vol. 131, No. 3, March 1984, pp. 637-640
5471	Signal Convexity and Noise Convexity of the Chernoff and Divergence Distances	Fishman, P.M. Jones, L.K.	IEEE Trans. Info. Theory, Vol. IT-30, No. 6, November 1984, pp. 854-856
5476	Analysis of an EHF Aplanatic Zoned Dielectric Lens Antenna	Rotman, W.	IEEE Trans. Antennas Propag., Vol. AP-32, No. 6, June 1984, pp. 611-617 ADA147584
5487	A System Executive for Real-Time Microcomputer Programs	Heath, W.S.	IEEE Micro, Vol. 4, No. 3, June 1984, pp. 20-32
5488	Experience with Speech Communication in Packet Networks	Weinstein, C.J. Forgie, J.W.	IEEE J. Selec. Areas Commun., Vol. SAC-1, No. 6, December 1983, pp. 963-980 ADA147058
5489	Laser Direct Writing for VLSI	Ehrlich, D.J. Tsao, J.Y.	VLSI Electronics: Microstructure Science, Vol. 7, Academic Press, New York, 1983, pp. 129-164
5495	Use of Plasma-Deposited Si ₃ N ₄ as an Oxidation Mask in the Fabrication of GaAs Shallow-Homojunction Solar Cells	Turner, G.W. Connors, M.K.	J. Electrochem. Soc., Vol. 131, No. 5, May 1984, pp. 1211-1213
5502	Generalized Analysis of Pressure Induced Nonlinear Optical Processes	Yee, S.T.K. Fujimoto, J.G.	Opt. Commun., Vol. 49, No. 5, 1 April 1984, pp. 376-382

JA No.			
5514	Low-Loss GaInAsP Buried-Heterostructure Optical Waveguide Branches and Bends	Johnson, L.M. Liau, Z-L. Groves, S.H.	Appl. Phys. Lett., Vol. 44, No. 3, 1 February 1984, pp. 278-280
5522	Broad-Band Guided-Wave Electrooptic Modulators	Becker, R.A.	IEEE J. Quantum Electron., Vol. QE-20, No. 7, July 1984, pp. 723-727
5525	A Compact Q-/K-Band Dual Frequency Feed Horn	Lee, J.C.	IEEE Trans. Antennas Propag., Vol. AP-32, No. 10, October 1984, pp. 1108-1111
5526	A Simple Method for Sampling In-Phase and Quadrature Components	Rader, C.M.	IEEE Trans. Aerosp. Electron. Syst., Vol. AES-20, No. 6, November 1984, pp. 821-824
5527	Zone-Melting Recrystalliza- tion of Thick Silicon on Insulator Films	Atwater, H.A. Smith, H.I. Thompson, C.V. Geis, M.W.	Mater. Lett., Vol. 2, No. 4A, March 1984, pp. 269-273
5528	Optimal Design of Amor- phous/Crystalline Tandem Cells	Fan, J.C.C. Palm, B.J.	Solar Cells, Vol. 11, No. 3, April 1984, pp. 247-261
5532	Maskless, Chemical Etching of Submicrometer Gratings in Single-Crystalline GaAs	Podlesnik, D.V. Gilgen, H.H. Osgood, R.M. Sanchez, A.	Appl. Phys. Lett., Vol. 43, No. 12, 15 December 1983, pp. 1083-1085
5534	Structural Characterization by Transmission Electron Microscopy of Silicon Grown Over Submicrometer-Period Gratings of Deposited Tungsten	Vojak, B.A. Rathman, D.D. Burns, J.A. Cabral, S.M. Efremow, N.N.	Appl. Phys. Lett., Vol. 44, No. 2, 15 January 1984, pp. 223-225 ADA147820
5535	Topographic Imperfections in Zone Melting Recrystallized Si Films on SiO ₂	Chen, C.K. Geis, M.W. Tsaur, B-Y. Chapman, R.L. Fan, J.C.C.	J. Electrochem. Soc., Vol. 131, No. 12, December 1984, pp. 1707-1711 ADA151482

JA No.

5536	Monolithic Silicon Bolometers	Downey, P.M. Jeffries, A.D. Meyer, S.S. Weiss, R.W. Bachner, F.J. Donnelly, J.P. Lindley, W.T. Mountain, R.W. Silversmith, D.J	Appl. Opt., Vol. 23, No. 6, 15 March 1984, pp. 910-914
5537	Electron-Beam Customization, Repair, and Testing of Wafer-Scale Circuits	Shaver, D.C.	Solid State Technol., Vol. 27, No. 2, February 1984, pp. 135-139
5538	Band Structure of α -Sn and Ge-Sn Alloys	Groves, S.H. Paul, W.	IEE Proc. I, Vol. 131, No. 3, June 1984, pp. 109-110
5539	Nonreciprocal Laser- Microchemical Processing: Spatial Resolution Limits and Demonstration of 0.2- μ m Linewidths	Ehrlich, D.J. Tsao, J.Y.	Appl. Phys. Lett., Vol. 44, No. 2, 15 January 1984, pp. 267-269 ADA147903
5542	Heterodyne Radiometry Measurements of the 557 GHz H ₂ O Rotational Line	Dionne, G.F. Fetterman, H.R. Erickson, N.R. Parker, C.D. Fitzgerald, J.F.	IEEE J. Quantum Electron., Vol. QE-20, No. 3, March 1984, pp. 188-190 ADA147785
5543	Exciton Transport in Optically Excited Al _x Ga _{1-x} As-GaAs Single Quantum Well	Le, H.Q. Lax, B. Maki, P.A. Palmateer, S.C. Eastman, L.F.	J. Appl. Phys., Vol. 55, No. 12, 15 June 1984, pp. 4367-4372
5544	Deep UV Exposure of Ag ₂ Se/GeSe ₂ Utilizing an Excimer Laser	Polasko, K.J. Ehrlich, D.J. Tsao, J.Y. Pease, R.F.W. Marinero, E.E.	IEEE Electron Device Lett., Vol. EDL-5, No. 1, January 1984, pp. 24-26

JA No.			
5545	Fabrication, Characterization, and Analysis of Mass-Transported GaInAsP/InP Buried- Heterostructure Lasers	Liau, Z-L. Walpole, J.N. Tsang, D.Z.	IEEE J. Quantum Electron., Vol. QE-20, No. 8, August 1984, pp. 855-865 ADA149328
5546	Efficient AlGaAs Shallow- Homojunction Solar Cells	Gale, R.P. Fan, J.C.C. Turner, G.W. Chapman, R.L. Pantano, J.V.	Appl. Phys. Lett., Vol. 44, No. 6, 15 March 1984, pp. 632-634
5547	Spectral Properties of Semiconductor Diode Lasers	Mooradian, A.	Proc. 23rd Scottish Univ. Summer School in Physics, Edinburgh, August 1982, pp. 213-234
5549	Dry Etching Induced Damage in Si and GaAs	Pang, S.W.	Solid State Technol., Vol. 27, No. 4, April 1984, pp. 249-256
5550	Mode-Locked Operation of Co:MgF ₂ and Ni:MgF ₂ Lasers	Johnson, B.C. Moulton, P.F. Mooradian, A.	Opt. Lett., Vol. 10, No. 4, April 1984, pp. 116-118 ADA147794
5551	Lasers, Their Development, and Applications at M.I.T. Lincoln Laboratory	Rediker, R.H. Melngailis, I. Mooradian, A.	IEEE J. Quantum Electron., Vol. QE-20, No. 6, June 1984, pp. 602-615
5553	Linewidth Measurements of a (GaAl)As Diode Laser with a High Reflectivity Coating	Lenth, W.	Appl. Phys. Lett., Vol. 44, No. 3, 1 February 1984, pp. 283-285
5554	Comments on "The Singular Integral Problem in Surfaces"	Heath, G.E.	IEEE Trans. Antennas Propag., Vol. AP-32, No. 4, April 1984, pp. 428-430
5557	Spatial-Resolution Limits of Laser Patterning: Submicrometer Projection Microchemistry	Ehrlich, D.J. Tsao, J.Y.	Mater. Res. Soc. Symp. Proc., Vol. 29, 1984, pp. 195-202 ADA149325

JA No.

5559	Passive Ti:LiNbO ₃ Channel Waveguide TE-TM Mode Splitter	Yap, D. Johnson, L.M. Pratt, G.W.	Appl. Phys. Lett., Vol. 44, No. 6, 15 March 1984, pp. 583-585
5560	Molecular Beam Epitaxy of GaAs and AlGaAs on Si	Tsaur, B-Y. Metze, G.M.	Appl. Phys. Lett., Vol. 45, No. 5, 1 September 1984, pp. 535-536 ADA147400
5561	A Self-Aligned Dual-Grating GaAs Permeable Base Transistor	Vojak, B.A. McClelland, R.W. Lincoln, G.A., Jr. Calawa, A.R. Flanders, D.C. Geis, M.W.	IEEE Electron Device Lett., Vol. EDL-5, No. 7, July 1984, pp. 270-272 ADA147252
5562	Residual Donors in LEC Indium Phosphide	Dean, P.J. Skolnick, M.S. Cockayne, B. MacEwan, W.R. Iseler, G.W.	J. Cryst. Growth, Vol. 67, No. 3, August 1984, pp. 486-494
5564	Signal Correlation Using a One-Dimensional Electro- absorptive CCD Spatial Light Modulator	Kingston, R.H.	Proc. IEEE, Vol. 72, No. 7, July 1984, pp. 954-961
5565	Amplitude Distribution of Composite Terrain Radar Clutter and the K-Distribution	Jao, J.K.	IEEE Trans. Antennas Propag., Vol. AP-32, No. 10, October 1984, pp. 1049-1062
5567	Voice and Data Communica- tions on an Experimental Wideband Internetwork System	Heggestad, H.M.	J. Telecommun. Networks, Vol. 3, No. 2, Summer 1984, pp. 131-146
5569	The Future of High-Efficiency Solar Cells	Fan, J.C.C.	Solar Cells, Vol. 12, No. 1-2, June-July 1984, pp. 51-62

JA No.			
5570	Annealing of Damage in Se ⁺ -Implanted Indium Phosphide	Woodhouse, J.D. Donnelly, J.P. Nitishin, P.M. Owens, E.B. Ryan, J.L.	Solid-State Electron., Vol. 27, No. 7, July 1984, pp. 677-686 ADA147972
5571	Laser Microchemical Techniques for Reversible Restructuring of Gate-Array Prototype Circuits	Ehrlich, D.J. Tsao, J.Y. Silversmith, D.J. Sedlacek, J.H.C. Mountain, R.W. Graber, W.S.	IEEE Electron Device Lett., Vol. EDL-5, No. 2, February 1984, pp. 32-35
5573	Molecular Astronomy Using Heterodyne Detection at 691 GHz	Peck, D.D. Fetterman, H.R. Buhl, D. Chin, G. Petuchowski, S.	Int. J. Infrared Millimeter Waves, Vol. 5, No. 3, March 1984, pp. 329-340
5574	X-Ray Photoelectron- Spectroscopy Study of the Chemical Structure of Thermally Nitrided SiO ₂	Vasquez, R.P. Hecht, M.H. Grunthaner, F.J. Naiman, M.L.	Appl. Phys. Lett., Vol. 44, No. 10, 15 May 1984, pp. 969-971
5575	The Effect of Base-Schottky Geometry on Si PBT Device Performance	Rathman, D.D. Vojak, B.A. Astolfi, D.K. Stern, L.A.	IEEE Electron Device Lett., Vol. EDL-5, No. 6, June 1984, pp. 191-193
5578	Patterned Photonucleation of Chemical Vapor Deposition of Al by UV-Laser Photodeposition	Tsao, J.Y. Ehrlich, D.J.	Appl. Phys. Lett., Vol. 45, No. 6, 15 Sep- tember 1984, pp. 617-619 ADA146896
5580	Flight Test Results for an Experimental GPS C/A-code Receiver in a General Aviation	Campbell, S.D. LaFrey, R.R.	Navigation, Vol. 30, No. 4, Winter 1983-1984, pp. 350-368

Aircraft

JA No.

5582	Triple Ion Implantation Technique for Formation of Shallow npn Bipolar Transistor Structures in Silicon	Tsaur, B-Y. Woodhouse, J.D.	Appl. Phys. Lett., Vol. 44, No. 10, 15 May 1984, pp. 1005-1007 ADA147995
5584	UV-Laser Photodeposition from Surface-Adsorbed Mix- tures of Trimethylaluminum and Titanium Tetrachloride	Tsao, J.Y. Ehrlich, D.J.	J. Chem. Phys., Vol. 81, No. 10, 15 November 1984, pp. 4620-4625 ADA149326
5585	Wide-Band Electrooptic Guided-Wave Analog-to- Digital Converters	Becker, R.A. Woodward, C.E. Leonberger, F.J. Williamson, R.C.	Proc. IEEE, Vol. 72, No. 7, July 1984, pp. 802-819
5586	Developments in Radar Imaging	Ausherman, D.A. Kozma, A. Walker, J.L. Jones, H.M. Poggio, E.C.	IEEE Trans. Aerosp. Electron. Syst., Vol. AES-20, No. 4, July 1984, pp. 363-400 ADA151533
5587	Spectral Characteristics of (GaAl)As Diode Lasers at 1.7 K	Harrison, J. Mooradian, A.	Appl. Phys. Lett., Vol. 45, No. 4, 15 August 1984, pp. 318-320 ADA147193
5590	Low Threshold GaInAsP/InP Buried-Heterostructure Lasers with a Chemically Etched and Mass-Transported Mirror	Liau, Z-L. Walpole, J.N. Tsang, D.Z.	Appl. Phys. Lett., Vol. 44, No. 10, 15 May 1984, pp. 945-947 ADA147996
5593	Unified Multiple-Beam Uplink Configuration for EHF Satellite Communications	Eaves, R.E. Kolba, D.P.	J. Spacecraft, Vol. 21, No. 1, January-February 1984, pp. 108-112
5595	Theoretical Analysis of Coherently Coupled Optical Waveguide Bends	Johnson, L.M. Yap, D.	Appl. Opt., Vol. 23, No. 17, 1 September 1984, pp. 2988-2990

JA No.			
5597	Growth and Patterning of GaAs/Ge Single-Crystal Layers on Si Substrates by Molecular Beam Epitaxy	Sheldon, P. Jones, K.M. Hayes, R.E. Tsaur, B-Y. Fan, J.C.C.	Appl. Phys. Lett., Vol. 45, No. 3, 1 August 1984, pp. 274-276
5599	GaAs MESFET's Fabricated on Monolithic GaAs/Si Substrates	Choi, H-K. Tsaur, B-Y. Metze, G.M. Turner, G.W. Fan, J.C.C.	IEEE Electron Device Lett., Vol. EDL-5, No. 6, June 1984, pp. 207-208
5600	Coupling Between Successive Ti:LiNbO ₃ Waveguide Bends and Branches	Yap, D. Johnson, L.M.	Appl. Opt., Vol. 23, No. 17, 1 September 1984, pp. 2991-2999 ADA148146
5601	Q-Switching of Low-Threshold Buried-Heterostructure Diode Lasers at 10 GHz	Tsang, D.Z. Walpole, J.N. Liau, Z-L. Groves, S.H. Diadiuk, V.	Appl. Phys. Lett., Vol. 45, No. 3, 1 August 1984, pp. 204-206 ADA147401
5602	On Initial Orbit Determination	Taff, L.G.	Astron. J., Vol. 89, No. 9, September 1984, pp. 1426-1428 ADA146912
5603	Multiple Waveguide Lens	Haus, H.A. Molter-Orr, L.A. Leonberger, F.J.	Appl. Phys. Lett., Vol. 45, No. 1, 1 July 1984, pp. 19-21
5606	Optical Interconnections for VLSI Systems	Goodman, J.W. Leonberger, F.J. Kung, S-Y. Athale, R.A.	Proc. IEEE, Vol. 72, No. 7, July 1984, pp. 850-866
5607	High Frequency Heterodyne Spectroscopy with Current- Modulated Diode Lasers	Lenth, W.	IEEE J. Quantum Electron., Vol. QE-20, No. 9, September 1984, pp. 1045-1050 ADA150628

JA No.

•••			
5608	Anomalous Saturated- Absorption Pressure Shifts in CO ₂	SooHoo, K.L. Freed, C. Thomas, J.E. Haus, H.A.	Phys. Rev. Lett., Vol. 53, No. 15, 8 October 1984, pp. 1437-1440
5611	Optimal Design of CdS- and Cd _{0.8} Zn _{0.2} S-Based Single-Junction and Multijunction Solar Cells	Fan, J.C.C. Palm, B.J.	Solar Cells, Vol. 12, No. 4, September 1984, pp. 401-420
5612	Effects of Ionizing Radiation on SOI/CMOS Devices Fabricated in Zone-Melting- Recrystallized Si Films on SiO ₂	Tsaur, B-Y. Mountain, R.W. Chen, C.K. Turner, G.W. Fan, J.C.C.	IEEE Electron Device Lett., Vol. EDI -5, No. 7, July 1984, pp. 238-240 ADA146975
5613	Experimental Tests of Open-Loop Maximum-Power- Point Tracking Techniques for Photovoltaic Arrays	Hart, G.W. Branz, H.M. Cox, C.H., III	Solar Cells, Vol. 13, No. 2, December 1984, pp. 185-195
5614	Low-Loss Multiple-Branching Circuit in Ti-Indiffused LiNbO ₃ Channel Waveguides	Becker, R.A. Johnson, L.M.	Opt. Lett., Vol. 9, No. 6, June 1984, pp. 246-248
5616	Frequency-Agile Electro-optically Q-Switched CO ₂ Laser for DIAL Measurements	Marcus, S.	Rev. Sci. Instrum., Vol. 55, No. 12, December 1984, pp. 1952-1954 ADA150587
5617	Computer-Aided Design of Quartz Elliptical Deflector Templates	Hovey, D.L.	Fusion, Vol. XXXI, No. 2, May 1984, pp. 42-45
5618	AlGaAs Double-Heterostructure Diode Lasers Fabricated on a Monolithic GaAs/Si Substrate	Windhorn, T.H. Metze, G.M. Tsaur, B-Y. Fan, J.C.C.	Appl. Phys. Lett., Vol. 45, No. 4, 15 August 1984, pp. 309-311 ADA147320
5620	Composite TaSi ₂ /n ⁺ Poly-Si Formation by Rapid Thermal Annealing	Kwong, D.L. Kwor, R. Tsaur, B-Y.	IEEE Electron Device Lett., Vol. EDL-5, No. 5, May 1984, pp. 133-135

JA NO.	J	A	No	١.
--------	---	---	----	----

5622	Oxygen in Zone-Melting- Recrystallized Silicon-On- Insulator Films: Its Distribution and Possible Role in Sub- Boundary Formation	Fan, J.C.C. Tsaur, B-Y. Chen, C.K. Dick, J.R. Kazmerski, L.L.	Appl. Phys. Lett., Vol. 44, No. 11, 1 June 1984, pp. 1086-1088
5623	Advances in LEC Growth of InP Crystals	Iseler, G.W.	J. Electron. Mater., Vol. 13, No. 6, November 1984, pp. 989-1011
5627	Picosecond Gain Measurements in a GaAlAs Diode Laser	Lenth, W.	Opt. Lett., Vol. 9, No. 9, September 1984, pp. 396-398 ADA147993
5635	Traveling-Wave Electro-optic Modulator with Maximum Bandwidth-Length Product	Becker, R.A.	Appl. Phys. Lett., Vol. 45, No. 11, I December 1984, pp. 1168-1170 ADA150629
5636	"Thermal Fixing" of Ti-indiffused LiNbO ₃ Channel Waveguides for Reduced Photorefractive Susceptibility	Becker, R.A.	Appl. Phys. Lett., Vol. 45, No. 2, 15 July 1984, pp. 121-123 ADA147195
5637	Optical Guided-Wave Gallium Arsenide Monolithic Interferometer	Donnelly, J.P. DeMeo, N.L. Jr. Ferrante, G.A. Nichols, K.B. O'Donnell, F.J.	Appl. Phys. Lett., Vol. 45, No. 4, 15 August 1984, pp. 360-362 ADA147251
5644	Use of Spatial Time-Division Repetition Rate Multiplication of Mode-Locked Laser Pulses to Generate Microwave Radiation from Opto- electronic Switches	Mooradian, A.	Appl. Phys. Lett., Vol. 45, No. 5, 1 September 1984, pp. 494-496 ADA147129
5646	Special Issue on ELF Communications, Guest Editorial	Burrows, M.L.	IEEE J. Oceanic Eng., Vol. OE-9, No. 3, July 1984, pp. 125-127

JA No.

5652	Merged CMOS/Bipolar Technologies Utilizing Zone-Melting-Recrystallized SOI Films	Tsaur, B-Y. Mountain, R.W. Chen, C.K. Fan, J.C.C.	IEEE Electron Device Lett., Vol. EDL-5, No. 11, November 1984, pp. 461-463
5653	Comparison of Laser-Initiated and Thermal Chemical Vapor Deposition of Tungsten Films	Deutsch, T.F. Rathman, D.D.	Appl. Phys. Lett., Vol. 45, No. 6, 15 September 1984, pp. 623-625 ADA147402
5654	Donor Identification in Liquid Phase Epitaxial Indium Phosphide	Skolnick, M.S. Dean, P.J. Groves, S.H. Kuphal, E.	Appl. Phys. Lett., Vol. 45, No. 9, 1 November 1984, pp. 962-964
5656	Metal-Semiconductor Field-Effect Transistors Fabricated in GaAs Layers Grown Directly on Si Substrates by Molecular Beam Epitaxy	Metze, G.M. Choi, H-K. Tsaur, B-Y.	Appl. Phys. Lett., Vol. 45, No. 10, 15 November 1984, pp. 1107-1109 ADA149001
5658	Long-Term Prospects for Lasers in Microfabrication	Ehrlich, D.J.	Laser Focus/Electro- Optics, Vol. 20, No. 10, October 1984, pp. 108-110
5676	Quantum Well Oscillators	Sollner, T.C.L.G. Tannenwald, P.E. Peck, D.D. Goodhue, W.D.	Appl. Phys. Lett., Vol. 45, No. 12, 15 December 1984, pp. 1319-1321 ADA150698

MEETING SPEECHES

MS No.			
5264	Recent Advances in Transition- Metal-Doped Tunable Lasers	Moulton, P.F. Mooradian, A.	Proc. Intl. Conf. on Lasers, Peking, China, May 1980, pp. 437-447
5899A	Raman Scattering as a Probe of Thin-Films	Brueck, S.R.J.	Proc. DARPA Workshop on Diamond-Like Carbon Coatings, 19-20 April 1982, pp. 214-223 ADP002599
5903	A Predictor Model for EHF Communication Satellite System Availabilities in the Presence of Rain	Schwab, L.M. Simmons, A.J.	31st Symp. of the Electromagnetic Wave Propagation Panel, 18-22 October 1982, pp. 25-1 — 25-11
5929	IR Detectors: Heterodyne and Direct	Spears, D.L.	Workshop on Optical and Laser Remote Sensing, Technical Digest, 9-11 February 1982, pp. H5-1 — H5-10
5931	Coherent IR Radar Technology	Gschwendtner, A.B. Harney, R.C. Hull, R.J.	Workshop on Optical and Laser Remote Sensing, Technical Digest, 9-11 February 1982, pp. J1-1 — J1-14
5959	S-Parameter Measurements Using a Time Interval Counter to Obtain Phase	Hodsdon, D.M.	ELECTRO '82, Boston, MA, 25-27 May 1982, pp. 4-1 — 4-4
6115	Complex Reflectivity and Refractive Index Profiles from Reflectivity Magnitude Measurements	Goldner, R.B. Quatieri, T.F. Grimbergen, M.N.	SPIE, Vol. 401, Thin Film Technologies, Geneva, Switzerland, 1983, pp. 206-210
6131A	Report on the Lincoln Boolean Synthesizer (LBS)	Southard, J.R. Domic, A. Crouch, K.W.	IEEE Intl. Conf. on Computer-Aided Design, Digest of Tech. Papers, 12-15 September 1983, pp. 192-193

MS No.

6232	Resolution and Accuracy, Ambiguity and Anomaly for Range-Spread Speckle Targets	Shapiro, J.H.	SPIE, Vol. 415, **oherent Infrared Radar Systems and Applications II, 1983, pp. 142-146 ADA147551
6233A	Superconductive Tapped Delay Lines for Low-Insertion-Loss Wideband Analog Signal-Processing Filters	Withers, R.S. Wright, P.V.	Proc. 37th Annual Frequency Control Symp., Philadelphia, PA, 1-3 June 1983, pp. 81-87
6240	LiNbO ₃ Guided-Wave Inter- ferometric Modulators	Leonberger, F.J.	Ferroelectrics, Vol. 50, No. 1-4, 1983, pp. 487-490
6277	Surface Photoacoustic Wave Spectroscopy of Adsorbed Molecules	Brueck, S.R.J. Deutsch, T.F. Oates, D.E.	Proc. 6th Intl. Conf. Laser Spectroscopy (SICOLS '83), 27 June — 1 July 1983, pp. 298-300
6289	Applications of LiNbO ₃ Guided-Wave Interferometric Modulators	Leonberger, F.J.	29th Intl. Instrumenta- tion Symp., 2-5 May 1983, pp. 247-259
6307A	Modification of Schottky Diode Characteristics in GaAs by Dry Etching	Pang, S.W. Lincoln, G.A. Geis, M.W. Vera, A.	Proc. IEEE/ Cornell Conf. on High-Speed Semicon- ductor Devices & Circuits, 15-17 August 1983, pp. 167-176
6311	Explicit Optimality Conditions for Fixed-Order Dynamic Compensation	Hyland, D.C. Bernstein, D.S.	Proc. 22nd IEEE Conf. on Decision & Control, San Antonio, TX, Vol. 1, 14-16 December 1983, pp. 161-165
6321	Programmable, Secondary Frequency Standard Based Infrared Synthesizer Using Tunable Lead-Salt Diode Lasers	Freed, C. Bielinski, J.W. Lo, W.	SPIE, Vol. 438, Tunable Diode Lasers Development and Spectroscopy Applications, 1983, pp. 119-123

MS No.			
6329A	Resonant Tunneling Through Quantum Wells up to 2.5 THz	Sollner, T.C.L.G. Goodhue, W.D. Tannenwald, P.E. Parker, C.D. Peck, D.D. Le, H.Q.	IEEE 8th Intl. Conf. on Infrared and Millimeter Waves, 12-17 December 1983, pp. T5.1-T5.2
6334	Quartz Rotary-Table Substrate Holder for Epitaxial Growth Reactor	Hovey, D.L.	Proc. 28th Symp. on the Art of Glassblowing, 13-17 June 1983, pp. 13-20, ADA147044
6335	The Application of Multi- channel Signal Processing to Clutter Suppression for a Moving Platform Radar	Shaw, G.A. McAulay, R.J.	IEEE Spectrum Estimation Workshop, Tampa, FL, 10-11 November 1983, pp. 308-312
6347	Calculation of Intrinsic Capacitances of GaAs FETs for Switching Circuits	Gopinath, A. Rankin, J.B.	Proc. IEEE/Cornell Conf. on High-Speed Semicon- ductor Devices & Circuits, 15-17 August 1983, pp. 309-316
6358	Adaptive Compensation for Atmospheric Turbulence Effects on Optical Propagation	Greenwood, D.P.	NATO AGARD Conf. Proc. No. 346, Spatind, Norway, 4-7 October 1983, pp. 18-1 — 18-10 ADP003897
6363	A Systolic Array Processor for Target Detection in Images	Therrien, C.W.	17th Asilomar Conf. on Circuits, Systems & Computers, 31 October — 2 November 1983, pp. 326-331
6375	Comparison of New Analog Device Technologies for Signal Processing	Stern, E.	Proc. of the Ultrasonics Symp., 31 October — 2 November 1983, pp. 129-136 ADA147473
6378	Measurement of Electroacoustic Coefficients in LiNbO ₃ and LiTaO ₃ and Application to Signal-Processing Devices	Gottschalk, P.G. Oates, D.E. Wright, P.V.	Proc. of the Ultrasonics Symp., 31 October — 2 November 1983, pp. 1091-1095 ADA147595

MS No.

6379	Surface-Photoacoustic-Wave Spectroscopy of Thin Films	Oates, D.E. Brueck, S.R.J. Deutsch, T.F.	Proc. of the Ultrasonics Symp., 31 October — 2 November 1983, pp. 695-699 ADA147515
6380	Recent Advances in Solid-State Laser Materials	Moulton, P.F.	Materials Research Society Symp. Proc., Vol. 24, 1984, pp. 393-400
6382	Electromagnetically-Induced Surface Microstructures and Enhanced Field Effects in Laser Processing	Brueck, S.R.J. Ehrlich, D.J. Murphy, D.V. Tsao, J.Y.	Materials Research Society Symp. Proc., Vol. 29, 1984, pp. 295-300 ADA147997
6385	Integration of Multiple Elastic Convolvers into a Communication Signal Processor	Dolat, V.S. Flynn, G.T.	Proc. of the Ultrasonics Symp., 31 October — 2 November 1983, pp. 137-142
6394	Laser Microchemical Processing: Spatial Resolution and Rate Limits of Optical Direct-Writing Techniques	Ehrlich, D.J. Tsao, J.Y.	Microcircuit Engineering '83, Academic Press, London, England, 1983, pp. 429-438
6397	UV Laser-Initiated Deposition of Al ₂ O ₃ Films: the Effect of Surface Irradiation	Deutsch, T.F. Silversmith, D.J. Mountain, R.W.	Materials Research Society Symp. Proc., Vol. 29, 1984, pp. 67-72
6400	Recent Advances in UV Laser Photodeposition	Tsao, J.Y. Ehrlich, D.J.	Materials Research Society Symp. Proc., Vol. 29, 1984, pp. 115-126
6400A	Laser-Chemical Modification of Nucleation Barriers for Area-Selective Thin Film Growth	Tsao, J.Y. Ehrlich, D.J.	J. Cryst. Growth, Vol. 68, No. 1, September 1984, pp. 176-187
6402	Laser Direct Write Technologies as Tools for Gate-Array Development	Silversmith, D.J. Ehrlich, D.J. Tsao, J.Y. Mountain, R.W. Sedlacek, J.H.C.	Materials Research Society Symp. Proc., Vol. 29, 1984, pp. 55-59 ADA147974

М		- T	0.
w	•	- 1	Λ
•		1 4	v.

6409	The Role of Oxygen in Zone-Melting Recrystallization of Silicon-on-Insulator Films	Fan, J.C.C. Tsaur, B-Y. Chen, C.K. Dick, J.R. Kazmerski, L.L.	Materials Research Society Symp. Proc., Vol. 23, 1984, pp. 477-489
6411	Laser Fabrication of Micron-Size Structures on CdS	Daneu, V. Peers, J.H. Sanchez, A.	Materials Research Society Symp. Proc., Vol. 29, 1984, pp. 133-137 ADA148266
6412	A CCD Chip for Parallel Pulse-Doppler Radar Processing	Chiang, A.M. Shaw, G.A.	ICASSP '84, IEEE Intl. Conf. on Acoustics, Speech & Signal Process., 19-21 March 1984, pp. 44.15.1-44.15.4
6413	A Wafer Scale Integration Systolic Processor for Connected Word Recognition	Feldman, J.A. Garverick, S.L. Rhodes, F.M. Mann, J.R.	ICASSP '84, IEEE Intl. Conf. on Acoustics, Speech & Signal Process., 19-21 March 1984, pp. 25B.4.1-25B.4.3
6414	Adaptive Noise Cancellation in a Fighter Cockpit Environment	Harrison, W.A. Lim, J.S. Singer, E.	ICASSP '84, IEEE Intl. Conf. on Acoustics, Speech & Signal Process., 19-21 March 1984, pp. 18A.4.1-18A.4.4
6416	A New Method For Wideband Sensor Array Processing	Nawab, S.H. Dowla, F.U. Lacoss, R.T.	ICASSP '84, IEEE Intl. Conf. on Acoustics, Speech & Signal Process., 19-21 March 1984, pp. 4.12.1-4.12.4
6417	Homomorphic Restoration of Images Degraded by Light Cloud Cover	Peli, T. Quatieri, T.F.	ICASSP '84, IEEE Intl. Conf. on Acoustics, Speech & Signal Process., 19-21 March 1984, pp. 37.8.1-37.8.4

MS No.

6418	Cancellation of Local Oscillator Intensity Noise Caused by the Relaxation Oscillation of GaAlAs Lasers with a Dual-Detector Heterodyne Receiver	Abbas, G.L. Chan, V.W.S. Yee, S.T.K.	Conf. on Optical Fiber Communication, New Orleans, LA, 23-25 Jan- uary 1984, p. 34
6420	Experiments with Extrapolating Band-Limited Signal	Tsai, M-J. O'Connor, D.A.	ICASSP '84, IEEE Intl. Conf. on Acoustics, Speech & Signal Process., 19-21 March 1984, pp. 31.9.1-31.9.4
6422	Performance Estimates for a Coherent Optical Commu- nication System	Jeromin, L.L. Chan, V.W.S.	Conf. on Optical Fiber Communication, New Orleans, LA, 23-35 January 1984, p. 60
6423	InP Optoelectronic Switches and Their High-Speed Signal-Processing Applications	Cox, C.H. III Diadiuk, V. Yao, I. Leonberger, F.J. Williamson, R.C.	SPIE, Vol. 439, Picosecond Optoelec- tronics, San Diego, CA, 24-26 September 1983, pp. 164-168 ADA147023
6431	Estimation of All-Pole Parameters from Noise- Corrupted Sequences	McGinn, D.P. Johnson, D.H.	IEEE ASSP Spectrum Workshop, Tampa, FL, 10-11 November 1983, pp. 108-112
6433	Fabrication and Characterization of Ti-Indiffused and Proton Exchange Waveguides in LiNbO ₃	Becker, R.A.	SPIE, Vol. 460, Processing of Guided Wave Optoelectronic Materials, 1984, pp. 95-100 ADA149327
6435	Wide-Bandwidth HgCdTe Photodiode Photomixers at 28 μm	Spears, D.L.	Eighth Intl. Conf. on Infrared & Millimeter Waves, 12-17 December 1983, Conf. Digest, p. T2.8

MS No.

6438	An Electroabsorptive CCD Spatial Light Modulator	Kingston, R.H. Burke, B.E. Nichols, K.B. Leonberger, F.J.	SPIE, Vol. 465, Spatial Light Modulators and Applications, 1984, pp. 9-11 ADA147194
6444	AlGaAs Shallow-Homojunction Solar Cells for Tandem Applications	Gale, R.P. Turner, G.W. Fan, J.C.C. Chapman, R.L. Pantano, J.V.	Proc. 17th IEEE Photovoltaic Specialists Conf., 1-4 May 1984, pp. 721-725 ADA147228
6445	A CCD Matrix-Matrix Product Parallel Processor	Chiang, A.M. Mountain, R.W. Silversmith, D.J. Felton, B.J.	1984 IEEE Intl. Solid-State Circuits Conf., Digest of Tech. Papers, 22-24 February 1984, pp. 110-111, & 336
6447	A High Stability TWTA for Ground Surveillance Applications	Millman, J.T. Saia, J.J. Hayse, C.E.	Proc. 1984 IEEE National Radar Conf., Atlanta, GA, 13-14 March 1984, pp. 110-114
6449A	A Microwave Phase and Gain Controller with Segmented-Dual-Gate MESFETs in GaAs MMICs	Hwang, Y.C. Chen, Y.K. Naster, R.J. Temme, D.H.	IEEE 1984 Microwave and Millimeter-Wave Monolithic Circuits Symp., Digest of Papers, 29-30 May 1984, pp. 1-5
6450	GaAs CLEFT Solar Cells for Space Applications	Fan, J.C.C. McClelland, R.W. King, B.D.	Proc. 17th IEEE Photovoltaic Specialists Conf., 1-4 May 1984, pp. 31-35 ADA147192
6452	GaAsP Shallow-Homojunction Solar Cells for Tandem Applications	McClelland, R.W. King, B.D. Fan, J.C.C. Chapman, R.L.	Proc. 17th IEEE Photovoltaic Specialists Conf., 1-4 May 1984, pp. 452-454 ADA147321

MS	No.

6456	GaAs/Ge/Si Solar Cells	Tsaur, B-Y. Fan, J.C.C. Turner, G.W. King, B.D. McClelland, R.W. Metze, G.M.	Proc. 17th IEEE Photovoltaic Specialists Conf., 1-4 May 1984, pp. 440-444 ADA147226
6461	Mutual Coupling in Monopole Phased Array Antennas	Fenn, A.J. Willwerth, F.G.	1984 Intl. Symp. Digest, Antennas and Propagation, Vol. II, Boston, MA, 25-28 June 1984, pp. 875-878
6463	A Distributed Aeroacoustic Tracking Algorithm	Tenney, R.R. Delaney, J.R.	Proc. 1984 American Control Conf., San Diego, CA, 6-8 June 1984, pp. 1440-1450 ADA146978
6465	Masked Ion Beam Lithography Using Stencil Masks	Randall, J.N. Flanders, D.C. Economou, N.P.	SPIE, Vol. 471, Electron- Beam, X-Ray, and Ion-Beam Techniques for Sub- micrometer Lithographies III, 1984, pp. 47-52
6470	An Ultra Low Transient GaAs FET VHF Switch	White, D.W.	1984 IEEE MTT-S Digest, 29 May — 1 June 1984, pp. 155-157
6472	100-Mbit/sec 4-ary Frequency Shift Key Modulation of a GaAlAs Semiconductor Diode Laser	Welford, D. Alexander, S.B.	Conf. on Lasers & Electro- Optics, Digest of Technical Papers, 19-22 June 1984, pp.108-109
6473	Compact Dual Frequency Reflector Antennas for EHF Mobile Satellite Communication Terminals	Rotman, W. Lee, J.C.	1984 Intl. Symp. Digest, Antennas and Propagation, Vol. I, Boston, MA, 25-28 June 1984, pp. 771-773
6475	Magnitude-Only Reconstruction Using a Sinusoidal Speech Model	McAulay, R.J. Quatieri, T.F.	ICASSP '84, IEEE Intl. Conf. on Acoustics, Speech & Signal Process., 19-21 March 1984, pp. 27.6.1-27.6.4

MS No.			
6483	Rapid Thermal Annealing of Composite TaSi ₂ /n ⁺ Poly-Si Silicide Films	Kwong, D.L. Kwor, R. Tsaur, B-Y. Daneshvar, K.	Materials Research Society Symp. Proc., Vol. 23, 1984, pp. 733-738
6497	Power Dropout Statistics of Nearly Single-Longitudinal- Mode Semiconductor Lasers	Abbas, G.L. Yee, S.T.K.	Conf. on Lasers & Electro-Optics, Digest of Technical Papers, 19-22 June 1984, pp. 212-213
6504	Moment-Method Scattering Solutions to Impedance Boundary Condition Integral Equations	Rogers, J.R.	1984 Intl. Symp. Digest, Antennas and Propagation, Vol. II, Boston, MA, 25-28 June 1984, pp. 347-350
6508	Measurement and/or Processing of Optical Wave Fronts Using Integrated Guided-Wave Optics	Rediker, R.H. Lind, T.A. Burke, B.E.	Conf. on Lasers & Electro-Optics, Digest of Technical Papers, 19-22 June 1984, pp. 196-198
6517	Recent Results in Coherent Optical Communication	Chan, V.W.S.	Conf. on Lasers & Electro-Optics, Digest of Technical Papers, 19-22 June 1984, pp. 108-110
6519	Interconnection and Testing of a Wafer-Scale Circuit with Laser Processing	Chapman, G.H. Anderson, A.H. Konkle, K.H. Mathur, B.P. Raffel, J.I. Soares, A.M.	Conf. on Lasers & Electro-Optics, Digest of Technical Papers, 19-22 June 1984, pp. 222-223
6523	4-Bit 1-G Sample/sec Electrooptic Guided-Wave Analog-to-Digital Converter	Becker, R.A. Woodward, C.E. Johnson, L.M. Leonberger, F.J.	Conf. on Lasers & Electro-Optics, Digest of Technical Papers, 19-22 June 1984, pp. 196-197
6524	Surface and Gas Processes in Photodeposition in Small Zones	Tsao, J.Y. Ehrlich, D.J.	SPIE, Vol. 459, Laser Assisted Deposition, Etching, and Doping, 1984, pp. 2-8

MS No.

6525	Flight Testing of TCAS II with Subject Pilots	Andrews, J.W.	IEE Colloquium on Airborne Collision Avoidance-TCAS, London, UK, 5 March 1984, pp. 3/1-3/4
6526	Development of Surveillance Techniques for TCAS II	Harman, W.H. III	IEE Colloquium on Airborne Collision Avoidance-TCAS, London, UK, 5 March 1984, pp. 2/1-2/4
6527	Progress in Surface Photoacoustic Wave Spectroscopy of Thin Films	Brueck, S.R.J. Deutsch, T.F. Oates, D.E.	Conf. on Lasers & Electro-Optics, Digest of Technical Papers, 19-22 June 1984, pp. 85-86
6528	Broadband Ti:LiNbO ₃ Guided-Wave Lumped-Element and Traveling-Wave Interfero- metric Modulators	Becker, R.A.	Seventh Topical Mtg. on Integrated and Guided- Wave Optics, Digest of Tech. Papers, 24-26 April 1984, pp. TuA2-1 — TuA2-4
6529	Laser Direct Writing: A Capsule Review of Methods and Applications in Microelectronics	Ehrlich, D.J. Tsao, J.Y.	Conf. on Lasers & Electro-Optics, Digest of Technical Papers, 19-22 June 1984, pp. 200-201
6530	Multiple Waveguide Lens	Haus, H.A. Molter-Orr, L.A. Leonberger, F.J.	Conf. on Lasers & Electro-Optics, Digest of Technical Papers, 19-22 June 1984, pp. 176-179
6536	Temperature Dependence of Quantum-Fluctuation Linewidth Broadening in (GaAl)As Diode Lasers	Harrison, J. Mooradian, A.	Thirteenth Intl. Quantum Electronics Conf., Digest of Technical Papers, 18-21 June 1984, pp. 45-46
6538	Integrated-Optical Channel-Waveguide Frequency Shifter	Johnson, L.M. Becker, R.A. Kingston, R.H.	Seventh Topical Mtg. on Integrated and Guided- Wave Optics, Digest of Tech. Papers, 24-26 April 1984, pp. WD4-1 — WD4-4

MS No.			
6540	Buried-Heterostructure Q-Switched Diode Lasers	Tsang, D.Z. Walpole, J.N. Liau, Z-L. Groves, S.H.	SPIE, Vol. 466, Optical Interfaces for Digital Circuits and Systems, 1984, pp. 40-44
6541	Electron-Beam Techniques for Integrated Circuit Testing and Customization	Shaver, D.C.	IEEE Proc. of the 1984 Custom Integrated Circuits Conf., Rochester, NY, 21-23 May 1984, pp. 606-609
6542	High Average Power Mode- Locked Operation of Co:MgF ₂ and Ni:MgF ₂ Lasers	Johnson, B.C. Moulton, P.F. Mooradian, A. Rosenbluh, M.	Conf. on Lasers & Electro-Optics, Digest of Technical Papers, 19-22 June 1984, p. 82
6543	Design, Fabrication and Characterization of Horn Antennas in Ti-indiffused LiNbO ₃ Channel Waveguides	Rediker, R.H. Lind, T.A. Becker, R.A. Johnson, L.M.	Seventh Topical Mtg. on Integrated and Guided- Wave Optics, Digest of Tech. Papers, 24-26 April 1984, pp. WC4-1 — WC4-4
6544	GaAs Monolithic Frequency Doublers with Series Connected Varactor Diodes	Chu, A. Courtney, W.E. Mahoney, L.J. McClelland, R.W. Atwater, H.A	IEEE 1984 Microwave & Millimeter Wave Monolithic Circuits Symp., Digest of Tech. Papers, 29-30 May 1984, pp. 74-77; also published in 1984 IEEE MTT-S Intl. Microwave Symp. Digest, 29 May — 1 June 1984, pp. 51-54
6548	Impedance Boundary Condition Integral Equations	Heath, G.E.	1984 Intl. Symp. Digest, Antennas and Propagation, Vol. II, Boston, MA, 25-28 June 1984, pp. 697-700
6553	A Gallium Arsenide Electro- optical Interferometric Modulator	Donnelly, J.P. DeMeo, N.L., Jr. Ferrante, G.A. Nichols, K.B. O'Donnell, F.J.	Seventh Topical Mtg. on Integrated and Guided- Wave Optics, Digest of Tech. Papers, 24-26 April 1984, pp. ThB3-1 — ThB3-4

MS No.

6556	Output Characteristics of Lead-Telluride Quantum-Well Diode Lasers	Freed, C. Bielinski, J.W. Lo, W. Partin, D.L.	J. Opt. Soc. Am. B, Vol. 1, No. 3, June 1984, pp. 544-545
6561	Characterization of Instability in Ti-indiffused LiNbO ₃ Modulators Due to Photorefractive and Non-Optical Sources	Becker, R.A.	Seventh Topical Mtg. on Integrated and Guided- Wave Optics, Digest of Tech. Papers, 24-26 April 1984, pp. WC3-1 — WC3-4
6562	Mass-Transported GaInAsP/InP Buried- Heterostructure Lasers and Integrated Mirrors	Liau, Z-L. Walpole, J.N. Tsang, D.Z.	Seventh Topical Mtg. on Integrated and Guided- Wave Optics, Digest of Tech. Papers, 24-26 April 1984, pp. TuC5-1 — TuC5-4
6564	Reconfiguring Semi-custom ICs Using Lasermicrochemical Techniques	Graber, W.S. Ehrlich, D.J. Tsao, J.Y. Silversmith, D.J. Sedlacek, J.H.C. Mountain, R.W.	IEEE Proc. 1984 Custom Integrated Circuits Conf., Rochester, NY, 21-23 May 1984, pp. 453-456
6574	High-Speed Integrated Optoelectronic Signal Processing Devices	Leonberger, F.J.	Seventh Topical Mtg. on Integrated and Guided- Wave Optics, Digest of Tech. Papers, 24-26 April 1984, pp. WA1-1 — WA1-3
6589	High-Field Electron Capture and Emission in Nitrided Oxides	Terry, F.L. Wyatt, P.W. Naiman, M.L. Mathur, B.P. Kirk, C.T., Jr. Senturia, S.D.	IEEE Trans. Electron Devices, Vol. ED-31, No. 12, December 1984, pp. 1971-1972
6590	A Simple Method for Sampling In-Phase and Quadrature Components	Rader, C.M. Sundaramurthy, M.	Proc. of the Microcircuit Applications Conf., 6-8 No- vember 1984, pp. 174-175

Meeting Speeches

MS No.

6628	GaAs Permeable Base Transistors Fabricated Using Organometallic Chemical Vapor Deposition	Nichols, K.B. Gale, R.P. Hollis, M.A. Lincoln, G.A., Jr. Bozler, C.O.	IEEE Trans. Electron Devices, Vol. ED-31, No. 12, December 1984, pp. 1968-1970
6632	Microwave Oscillations and Optical Effects from Resonant Tunneling Quantum Well Structures	Sollner, T.C.L.G. Tannenwald, P.E. Goodhue, W.D. Peck, D.D. Le, H.Q.	IEEE Trans. Electron Devices, Vol. ED-31, No. 12, December 1984, p. 1985
6634	A Tracking Algorithm for Dense Target Environments	Chang, C-B. Dunn, K-P. Youens, L.C.	Proc. 1984 American Control Conf., San Diego, CA, 6-8 June 1984, pp. 613-618
6635	Low Frequency Noise in Permeable Base Transistors	Zhu, X.C. Zhang, X.N. van der Ziel, A. Bozler, C.O.	IEEE Trans. Electron Devices, Vol. ED-31, No. 10, October 1984, pp. 1408-1413
6637	Lateral Photodetectors on Semi-Insulating InGaAs and InP	Diadiuk, V. Groves, S.H.	IEEE Trans. Electron Devices, Vol. ED-31, No. 12, December 1984, p. 1973
6640	Silicon Permeable Base Transistors	Rathman, D.D. Vojak, B.A. Flanders, D.C. Economou, N.P.	1984 Intl. (16th) Conf. on Solid State Devices and Materials, 30 August — 1 September 1984, pp. 305-308
6646	Optical Analysis of Device Materials: Structures and Processing	Brueck, S.R.J.	Conf. on Lasers & Electro-Optics, Digest of Technical Papers, 19-22 June 1984, p. 200
6647	14-GHz Operation of Q-Switched Diode Lasers	Tsang, D.Z. Walpole, J.N. Groves, S.H. Liau, Z-L.	IEEE Trans. Electron Devices, Vol. ED-31, No. 12, December 1984, pp. 1973-1974

Meeting Speeches

MS No.

6651	A New High-Efficiency GaAs Solar Cell Structure Using a Heterostructure Back-Surface Field	Gale, R.P. Fan, J.C.C. Turner, G.W. Chapman, R.L.	Proc. 17th IEEE Photovoltaic Specialists Conf., 1-4 May 1984, pp. 1422-1425 ADA147534
6652	GaAs MESFETs and AlGaAs Double-Heterostructure Diode Lasers Fabricated on Mono- lithic GaAs/Si Substrates	Choi, H-K. Windhorn, T.H. Tsaur, B-Y. Metze, G.M. Turner, G.W. Fan, J.C.C.	IEEE Trans. Electron Devices, Vol. ED-31, No. 12, December 1984, p. 1988
6665	Restructurable VLSI for Real-Time Signal and Data Processing Applications	Sundaramurthy, M.	IEEE 1984 Digital Signal Processing Workshop, 8-10 October 1984, pp. 6.2.1-6.2.2
6674	Monolithic Integration of GaAs and Si	Fan, J.C.C.	1984 Intl. (16th) Conf. on Solid State Devices and Materials, 30 August — 1 September 1984, pp. 115-119
6737	Spatial Tracking System for Heterodyne Optical Communication	Swanson, E.A. Chan, V.W.S.	IEEE Military Commun. Conf., Vol. 2, Conf. Rec., 21-24 October 1984, pp. 253-258

AUTHOR INDEX

Abbas, G.L., MS-6418, MS-6497

Alexander, S.B., MS-6472

Anderson, A.H., TR-707, MS-6519

Anderson, J.C., TR-707

Andrews, J.W., MS-6525

Astolfi, D.K., JA-5575

Athale, R.A., JA-5606

Atwater, H.A., JA-5527, MS-6544

Aucoin, R.J., JA-5468

Ausherman, D.A., JA-5586

Bachner, F.J., JA-5536

Becker, R.A., JA-5522, JA-5585, JA-5614, JA-5635, JA-5636, MS-6433, MS-6523, MS-6528, MS-6538, MS-6543, MS-6561

Berger, R., TR-681

Bernstein, D.S., MS-6311

Bielinski, J.W., MS-6321, MS-6556

Bowers, C.J., TR-671

Bozler, C.O., TR-669, MS-6628, MS-6635

Branz, H.M., JA-5613

Brueck, S.R.J., MS-5899A, MS-6277, MS-6379, MS-6382, MS-6527, MS-6646

Buhl, D., JA-5573

Burke, B.E., MS-6438, MS-6508

Burns, J.A., JA-5534

Burrows, M.L., JA-5646

Cabral, S.M., JA-5534

Calawa, A.R., JA-5561

Campbell, S.D., JA-5580

Chan, V.W.S., TR-667, MS-6418, MS-6422, MS-6517, MS-6737

Chang, C-B., TR-694, JA-5297, MS-6634

Chapman, G.H., MS-6519

Chapman, R.L., JA-5535, JA-5546, MS-6444, MS-6452, MS-6651

Chen, C.K., JA-5535, JA-5612, JA-5622, JA-5652, MS-6409

Chen, Y.K., MS-6449A

Chiang, A.M., MS-6412, MS-6445

Chin, G., JA-5573

Choi, H-K., JA-5599, JA-5656, MS-6652

Chu, A., MS-6544

Cockayne, B., JA-5562

Connors, M.K., JA-5495

Courtney, W.E., MS-6544

Cox, C.H. III, JA-5613, MS-6423

Crouch, K.W., MS-6131A

Daneshvar, K., MS-6483

Daneu, V., MS-6411

Dean, P.J., JA-5562, JA-5654

Delaney, J.R., MS-6463

DeMeo, N.L., Jr., JA-5637, MS-6553

Dervisoglu, B.I., TR-685

Deutsch, T.F., JA-5653, MS-6277, MS-6379, MS-6397, MS-6527

Diadiuk, V., JA-5601, MS-6423, MS-6637

Dick, J.R., JA-5622, MS-6409

Dion, A.R., TR-662

Dionne, G.F., TR-688, JA-5542

Dolat, V.S., MS-6385

Domic, A., MS-6131A

Donnelly, J.P., JA-5536, JA-5570, JA-5637, MS-6443

Dowla, F.U., MS-6416

Downey, P.M., JA-5536

Dudgeon, D.E., TR-705

Dunn, K-P., TR-686, TR-694, MS-6634

Eastman, L.F., JA-5543

Eaves, R.E., JA-5593

Economou, N.P., MS-6465, MS-6640

Efremow, N.N., JA-5534

Ehrlich, D.J., JA-5489, JA-5539, JA-5544, JA-5557, JA-5571, JA-5578, JA-5584, JA-5658, MS-6382, MS-6394, MS-6400, MS-6400A, MS-6402, MS-6524, MS-6529, MS-6564

Erickson, N.R., JA-5542

Fan, J.C.C., TR-669, JA-5528, JA-5535, JA-5546, JA-5569, JA-5597, JA-5599, JA-5611, JA-5612, JA-5618, JA-5622, JA-5652, MS-6409, MS-6444, MS-6450, MS-6452, MS-6651, MS-6652, MS-6674

Feldman, J.A., MS-6413

Felton, B.J., MS-6445

Fenn, A.J., MS-6461

Ferrante, G.A., JA-5637, MS-6553

Fetterman, H.R., JA-5542, JA-5573

Fitzgerald, J.F., JA-5542

Flanders, D.C., JA-5561, MS-6465, MS-6640

Flynn, G.T., MS-6385

Forgie, J.W., JA-5488

Freed, C., JA-5608, MS-6321, MS-6556

Fujimoto, J.G., JA-5502

Fukunaga, K., JA-5425

Gale, R.P., JA-5546, MS-6444, MS-6628, MS-6651

Garverick, S.L., MS-6413

Geis, M.W., JA-5527, JA-5535, JA-5561, MS-6307A

Gilgen, H.H., JA-5532

Gold, B., TR-671, TR-680

Goldner, R.B., MS-6115

Goodhue, W.D., JA-5676, MS-6329A, MS-6632

Goodman, J.W., JA-5606

Gopinath, A., MS-6347

Gottschalk, P.G., MS-6378

Graber, W.S., JA-5571, MS-6564

Greenwood, D.P., MS-6358

Grimbergen, M.N., MS-6115

Groves, S.H., JA-5514, JA-5538, JA-5601, JA-5654, MS-6540, MS-6637, MS-6647

Grunthaner, F.J., JA-5574, JA-5700

Gschwendtner, A.B., MS-5931

Harman, W.H. III, MS-6526

Harney, R.C., MS-5931

Harrison, J., JA-5587, MS-6536

Harrison, W.A., TR-691, MS-6414

Hart, G.W., JA-5613

Haus, H.A., JA-5429, JA-5603, JA-5608, MS-6530

Hayes, R.E., JA-5597

Hayse, C.E., MS-6447

Heath, G.E., JA-5554, MS-6548

Heath, W.S., JA-5487

Hecht, M.H., JA-5574, JA-5700

Heggestad, H.M., TR-681, JA-5454, JA-5567

Hodsdon, D.M., MS-5959

Hollis, M.A., MS-6628

Hovey, D.L., JA-5617, MS-6334

Hull, R.J., MS-5931

Hwang, Y.C., MS-6449A

Hyland, D.C., MS-6311

Iseler, G.W., JA-5562, JA-5623

Jao, J.K., JA-5565

Jeffries, A.D., JA-5536

Jeromin, L.L., MS-6187A, MS-6422

Johnson, B.C., JA-5550, MS-6542

Johnson, D.H., MS-6431

Johnson, L.M., JA-5514, JA-5559, JA-5595, JA-5600, JA-5614, MS-6523, MS-6538, MS-6543 Jones, H.M., JA-5586

Jones, K.M., JA-5597

Kazmerski, L.L., JA-5622, MS-6409

Kelly, E.J., TR-709

King, B.D., MS-6450, MS-6452, MS-6456

Kingston, R.H., JA-5564, MS-6438, MS-6538

Kirk, C.T., Jr., JA-5468, MS-6589

Kocher, D.G., JA-5399

Kolba, D.P., JA-5593

Konkle, K.H., MS-6519

Kozma, A., JA-5586

Kung, S-Y., JA-5606

Kuphal, E., JA-5654

Kwong, D.L., JA-5620, MS-6483

Kwor, R., JA-5620, MS-6483

Lacoss, R.T., MS-6416

LaFrey, R.R., JA-5580

Lax, B., JA-5543

Le, H.Q., JA-5543, MS-6329A, MS-6632

Lee, J.C., JA-5525, MS-6473

Lenth, W., JA-5553, JA-5607, JA-5627

Leonberger, F.J., JA-5429, JA-5585, JA-5603, JA-5606, MS-6240, MS-6289, MS-6423, MS-6438, MS-6523, MS-6530, MS-6574

Lerner, R.M., TR-684

Liau, Z-L., JA-5514, JA-5545, JA-5590, JA-5601, MS-6540, MS-6562, MS-6647

Lim, J.S., MS-6414

Lincoln, G.A., Jr., JA-5561, MS-6307A, MS-6628

Lind, T.A., MS-6508, MS-6543

Lindley, W.T., JA-5536

Lippmann, R.P., TR-681

Lo, W., MS-6321, MS-6556

Lynch, J.T., TR-671

MacEwan, W.R., JA-5562

Mack, M.A., TR-680

Mahoney, L.J., MS-6544

Maki, P.A., JA-5543

Mann, J.R., MS-6413

Marcus, S., JA-5616

Marinero, E.E., JA-5544

Mathur, B.P., MS-6519, MS-6589

Mavroides, J.G., TR-669

Mayer, G.J., TR-634

McAulay, R.J., JA-5356, MS-6335, MS-6475

McClelland, R.W., TR-669, JA-5561, MS-6450, MS-6452, MS-6456, MS-6544

McGinn, D.P., MS-6431

Melngailis, I., JA-5551

Metze, G.M., JA-5560, JA-5599, JA-5618, JA-5656, MS-6456, MS-6652

Meyer, S.S., JA-5536

Millman, J.T., MS-6447

Molter-Orr, L.A., JA-5429, JA-5603, MS-6530

Mooradian, A., JA-5547, JA-5550, JA-5551, JA-5587, JA-5644, MS-5264, MS-6536, MS-6542

Moulton, P.F., JA-5550, MS-5264, MS-6380, MS-6542

Mountain, R.W., JA-5536, JA-5571, JA-5612, JA-5652, MS-6397, MS-6402, MS-6445, MS-6564

Muresan, L.V., TR-662

Murphy, D.V., MS-6382

Naiman, M.L., JA-5468, JA-5574, JA-5700, MS-6589

Naster, R.J., MS-6449A

Nawab, S.H., MS-6416

Nichols, K.B., JA-5637, MS-6438, MS-6553, MS-6628

Nitishin, P.M., JA-5570

Oates, D.E., MS-6277, MS-6378, MS-6379, MS-6527

O'Connor, D.A., MS-6420

O'Donnell, F.J., JA-5637, MS-6553

Osgood, R.M., JA-5532

Owens, E.B., JA-5570

Palm, B.J., JA-5528, JA-5611

Palmateer, S.C., JA-5543

Pang, S.W., JA-5549, MS-6307A

Pantano, J.V., JA-5546, MS-6444

Parker, C.D., JA-5542, MS-6329A

Partin, D.L., MS-6556

Paul, D.B., TR-676

Paul, W., JA-5538

Pease, R.F.W., JA-5544

Peck, D.D., JA-5573, JA-5676, MS-6329A,

MS-6632

Peers, J.H., MS-6411

Peli, E., JA-5464

Peli, T., JA-5464, MS-6417

Petuchowski, S., JA-5573

Podlesnik, D.V., JA-5532

Poggio, E.C., JA-5586

Polasko, K.J., JA-5544

Pratt, G.W., JA-5559

Quatieri, T.F., TR-705, MS-6115,

MS-6417, MS-6475

Rader, C.M., JA-5526, MS-6590

Raffel, J.I., MS-6519

Randall, J.N., MS-6465

Randall, P.M.S., TR-618

Rankin, J.B., MS-6347

Rathman, D.D., JA-5534, JA-5575,

JA-5653, MS-6640

Rediker, R.H., JA-5551, MS-6508,

MS-6543

Rhodes, F.M., MS-6413

Rogers, J.R., MS-6504

Rosenbluh, M., MS-6542

Rotman, W., JA-5476, MS-6473

Ryan, J.L., JA-5570

Saia, J.J., MS-6447

Salerno, J.P., TR-669

Sanchez, A., JA-5532, MS-6411

Schecter, H., TR-683

Schwab, L.M., MS-5903

Sedlacek, J.H.C., JA-5571, MS-6402,

MS-6564

Senturia, S.D., JA-5468, MS-6589

Shapiro, J.H., MS-6232

Shaver, D.C., JA-5537, MS-6541

Shaw, G.A., MS-6335, MS-6412

Sheldon, P., JA-5597

Silversmith, D.J., JA-5536, JA-5571,

MS-6397, MS-6402, MS-6445, MS-6564

Simmons, A.J., MS-5903

Singer, E., TR-712, MS-6414

Skolnick, M.S., JA-5562, JA-5654

Smith, H.I., JA-5527

Smith, M.L., TR-699

Soares, A.M., MS-6519

Sollner, T.C.L.G., JA-5676, MS-6329A,

MS-6632

SooHoo, K.L., JA-5608

Sorvari, J.M., TR-701

Southard, J.R., MS-6131A

Spears, D.L., MS-5929, MS-6435

Stansfield, S.A., TR-618

Stern, E., MS-6375

Stern, L.A., JA-5575

Sundaramurthy, M., MS-6590, MS-6665

Swanson, E.A., MS-6737

Tabaczynski, J.A., JA-5297

Taff, L.G., TR-618, JA-5452, JA-5602

Tannenwald, P.E., JA-5676, MS-6329A, MS-6632

Temme, D.H., MS-6449A

Tenney, R.R., MS-6463

Terry, F.L., JA-5468, MS-6589

Therrien, C.W., TR-705, JA-5425, MS-6363

Thomas, J.E., JA-5608

Thompson, C.V., JA-5527

Tierney, J., TR-671, TR-683

Tsai, M-J., TR-689, MS-6420

Tsang, D.Z., JA-5545, JA-5590, JA-5601,

MS-6540, MS-6562, MS-6647

Tsao, J.Y., JA-5489, JA-5539, JA-5544, JA-5557, JA-5571, JA-5578, JA-5584,

MS-6382, MS-6394, MS-6400, MS-6400A,

MS-6402, MS-6524, MS-6529, MS-6564

Tsaur, B-Y., JA-5535, JA-5560, JA-5582, JA-5597, JA-5599, JA-5612, JA-5618,

JA-5620, JA-5622, JA-5652, JA-5656,

MS-6409, MS-6456, MS-6483, MS-6652

Turner, G.W., JA-5495, JA-5546, JA-5599, JA-5612, MS-6444, MS-6456, MS-6651, MS-6652

van der Ziel, A., MS-6635

Van Hove, P., TR-667, MS-6198A

Vasquez, R.P., JA-5574

Vera, A., MS-6307A

Vohl, P., TR-669

Vojak, B.A., JA-5534, JA-5561, JA-5575, MS-6640

Walker, J.L., JA-5586

Walpole, J.N., JA-5545, JA-5590, JA-5601, MS-6540, MS-6562, MS-6647

Weiner, S.D., TR-677

Weinstein, C.J., JA-5488

Weiss, R.W., JA-5536

Welford, D., MS-6472

White, D.W., MS-6470

White, F.M., TR-654

Williamson, R.C., JA-5585, MS-6423

Willwerth, F.G., MS-6461

Windhorn, T.H., JA-5618, MS-6652

Withers, R.S., JA-5465, MS-6233A

Woodhouse, J.D., JA-5570, JA-5582

Woodward, C.E., JA-5585, MS-6523

Wright, P.V., MS-6233A, MS-6378

Wyatt, P.W., JA-5468, MS-6589

Yao, I., MS-6423

Yap, D., JA-5559, JA-5595, JA-5600

Yee, S.T.K., JA-5502, MS-6418, MS-6497

Youens, L.C., MS-6634

Zhang, X.N., MS-6635

Zhu, X.C., MS-6635

SUBJECT INDEX

A/D CONV^CRTER JA-5585, MS-6240, MS-6289, MS-6574

ABSORPTION JA-5608

ABSORPTION SPECTRA MS-6277, MS-6379

ACCEPTANCE TESTS TR-683

ACOUSTIC NOISE TR-683

ACOUSTIC SENSORS MS-6463

ACOUSTIC TRACKING MS-6416

ACOUSTIC WAVES JA-5465

ADAPTIVE FILTERS MS-6417

ADAPTIVE IMAGE ENHANCEMENT JA-5464

ADAPTIVE NOISE TR-691, MS-6414

ADSORBED MOLECULES MS-6277

ADSORPTION JA-5584

AEROACOUSTICS MS-6463

AID (SEE AIRBORNE INTELLIGENT DISPLAY)

AIR ROUTE SURVEILLANCE RADAR MS-6525

AIR-TO-AIR MS-6526 AIR-TO-GROUND JA-5586

AIRBORNE TR-701

AIRBORNE INTELLIGENT DISPLAY MS-6525

AIRCRAFT JA-5580

AlGaAs (SEE ALUMINUM GALLIUM ARSENIDE)

ALGORITHMS TR-667, TR-686, TR-689, TR-691, TR-699, MS-6431, MS-6634

ALL-POLE MODELING MS-6431

ALUMINUM JA-5571, JA-5578

ALUMINUM ALLOYS MS-6402

ALUMINUM GALLIUM ARSENIDE JA-5543, JA-5546, JA-5560, JA-5618, MS-6444, MS-6652, MS-6674

ALUMINUM OXIDE MS-6380, MS-6397

AMBIGUITY RESOLUTION MS-6232, MS-6634

AMORPHOUS SILICON HYDRIDE JA-5528

AMORPHOUS SUBSTRATES JA-5570

AMORPHOUS-CRYSTALLINE TANDEM CELL JA-5528

AMPLITUDE JA-5565, JA-5603, JA-5607

AMPLITUDE CALIBRATION MS-6553

ANALOG SIGNAL PROCESSING MS-6233A, MS-6375

ANALOG-TO-DIGITAL CONVERSION MS-6523

ANALYSIS TR-667, JA-5476

ANGLE OF ARRIVAL TR-654

ANGLES ONLY DATA TR-618

ANGULAR VELOCITY TR-618

ANISOTROPY TR-688, JA-5549

ANNEALING JA-5570, JA-5574, JA-5582

ANODIC OXIDATION JA-5495, JA-5546

ANOMALIES MS-6232

ANTENNA BEAMS JA-5593

ANTENNAS TR-662

APLANATIC ZONED LENS JA-5476

ARCHITECTURE TR-712

AREA DEFENSE TR-677

ARGON MS-6307A, MS-6411 ARGON FLUORIDE LASER JA-5653, MS-6397

ARPANET JA-5488

ARRAY PROCESSING MS-6416

ARSENIC JA-5582

ARTIFICIAL SATELLITES TR-618, JA-5602

ASTEROID SEARCH JA-5452

ASTEROIDS TR-618, JA-5452

ASTRONOMICAL REFRACTION TR-701

ASTRONOMY JA-5573, JA-5602

ATMOSPHERE TR-686

ATMOSPHERIC MODELS TR-686

ATMOSPHERIC REFRACTION TR-686, TR-701

ATMOSPHERIC TURBULENCE MS-6358

ATTENUATION MS-5903

AUDITORY MODEL TR-707

AUGER ELECTRON SPECTROSCOPY MS-6483

AUTOCORRELATION MS-6431

BARRIERS AUTOMATIC FOCUSING JA-5399 MS-6329A **AUTOVON BATTLEFIELD SURVEILLANCE** TR-681 MS-6447 **AVALANCHE PHOTODETECTORS BAYES-OPTIMAL ESTIMATION** MS-6187A TR-654 **AVALANCHE PHOTODIODES BEAM SCANNING** JA-5644, MS-6523 JA-5578 **AVIONICS BEAM SPLITTING** JA-5580 MS-6418 **BEAM SPREADING** MS-6358 **BACK-SURFACE FIELD** MS-6651 **BENDS BACKGROUND NOISE** JA-5514, JA-5600 MS-6414 **BICRYSTAL BACKWARD-WAVE OSCILLATOR** TR-669 JA-5542 **BINARY STARS BALLISTIC KALMAN FILTER** JA-5602 TR-699 **BIPOLAR TECHNOLOGY BALLISTIC MISSILE DEFENSE** JA-5652 TR-677 **BIPOLAR TRANSISTORS BALLISTIC TRAJECTORY** JA-5582 TR-699 **BLOCK CODES** BAND LIMITED COMMUNICATION MS-6187A MS-6420, MS-6590 **BODIES OF REVOLUTION BAND STRUCTURE** TR-709 JA-5538 **BOLOMETERS BANDGAP** JA-5536 JA-5569 **BONDING BANDWIDTH** TR-669 JA-5635 **BOOLEAN FUNCTIONS BANDWIDTH LIMITATIONS** MS-6131A TR-681 **BORON BANDWIDTH MEASUREMENTS** JA-5582 MS-6590

BRANCHING JA-5514, JA-5600

BROADBAND JA-5522, JA-5559, MS-6528

BSF (SEE BACK-SURFACE FIELD)

BURIED CHANNEL CHARGE-COUPLED DEVICE MS-6438

BURIED HETEROSTRUCTURE JA-5514, JA-5545, JA-5590, JA-5601, MS-6540, MS-6562

C-BAND MS-6447

C-PROGRAMMING LANGUAGE JA-5487

C A CODE RECEIVER JA-5580

CADMIUM SULFIDE JA-5611, MS-6411

CAPACITANCE MS-6347

CARBON DIOXII & LASERS JA-5551, JA-5578, JA-5608, JA-5616, MS-5931, MS-6321

CARCINOTRONS JA-5542

CARRIER CONCENTRATIONS TR-669

CATHODOLUMINESCENCE TR-669

CATION TR-688

CCD (SEE CHARGE-COUPLED DEVICES)

CCD CORRELATOR MS-6574

CCS (SEE COMMON-CHANNEL SIGNALING)

CELESTIAL MECHANICS JA-5602

CHANNEL ERROR TR-683

CHANNEL OPERATION JA-5570

CHANNEL VOCODER TR-671, TR-707

CHANNEL WAVEGUIDE JA-5636

CHANNELIZATION SYSTEMS MS-6543

CHARGE TRANSFER FUNCTIONS
JA-5564

CHARGE-COUPLED DEVICES JA-5564, MS-6375, MS-6412, MS-6438, MS-6445, MS-6508

CHARGED PARTICLES
JA-5554

CHEMICAL ETCHING JA-5532, JA-5590, MS-6307A

CHEMICAL LASERS JA-5550

CHEMICAL STRUCTURE JA-5574

CHEMICAL VAPOR DEPOSITION
JA-5468, JA-5489, JA-5560, JA-5578,
JA-5617, JA-5653, MS-6397, MS-6400,
MS-6400A, MS-6402, MS-6452,
MS-6628, MS-6674

CHIPS JA-5606, MS-6131A

CIRCUIT BOARDS MS-6385

CIRCUIT SWITCHED NETWORK TR-681, JA-5567

CLEAVAGE LATERAL EPITAXIAI.
FILM TRANSFER
MS-6450

CLEFT (SEE CLEAVAGE LATERAL EPITAXIAL FILM TRANSFER)

CLIMATOLOGY MS-5903

CLOCK DISTRIBUTION JA-5606

CLUTTER JA-5565

CLUTTER SUPPRESSION MS-6335

CMOS JA-5571, JA-5612, JA-5652,

MS-6131A, MS-6402

COATINGS JA-5553

COBALT TR-688, JA-5550, MS-6542

COBALT ANISOTROPY AND RELAXATION TR-688

COBALT MAGNESIUM FLUORIDE LASER JA-5550, MS-5264, MS-6380, MS-6542

COCKPIT MS-6414

CODED SYSTEM MS-6187A

CODING MS-6475

COHERENT APPLICATIONS MS-6438

COHERENT COUPLING JA-5595

COHERENT INFRARED RADAR MS-5931

COHERENT LASERS JA-5603, MS-6232

COHERENT OPTICAL COMMUNI-CATION SYSTEMS MS-6187A, MS-6418, MS-6422, MS-6517

COLLISION AVOIDANCE MS-6526

COMMON-CHANNEL SIGNALING TR-681

COMMUNICATION SATELLITES MS-5903

COMMUNICATIONS TR-681, JA-5646, MS-6385

COMPOSITE TERRAIN
JA-5565

COMPUTER AIDED DESIGN JA-5617

COMPUTER ANALYSIS JA-5528, JA-5611

COMPUTER MODEL MS-5903

CONNECTED WORD RECOGNITION MS-6413

CONTAMINATION JA-5549

CONTINUOUS WAVE LASERS JA-5429, MS-5264, MS-6411

CONTRAST MANIPULATION JA-5464

CONTRAST SENSITIVITY JA-5464

CONTROL LOGIC MS-6526

CONTROL THEORY MS-6311

CONVERSION EFFICIENCIES
JA-5528, JA-5546, JA-5611, MS-6538

CORRELATION JA-5564

COST EFFECTIVENESS JA-5528

COSTS JA-5611

COUPLED MODE ANALYSIS
JA-5614

COUPLING JA-5600

COVARIANCE MATRIX JA-5425, MS-6363

CRAMER-RAO BOUND TR-654, TR-694, JA-5297, MS-6232

CREW RESPONSE MS-6525

CRYSTAL DEFECTS JA-5534

CRYSTALLIZATION JA-5570

CRYSTALLOGRAPHY JA-5527

CRYSTALS JA-5623, MS-6380 CUEING MS-6363

CURRENTS JA-5676

CUSTOMIZATION JA-5537, MS-6541

CVD (SEE CHEMICAL VAPOR DEPOSITION)

CW LASERS (SEE CONTINUOUS WAVE LASERS)

DAMAGE JA-5570

DATA ACQUISITION SYSTEMS JA-5586

DATA COMMUNICATION JA-5567

DATA PROCESSING JA-5586

DEEP LEVEL TRANSIENT SPECTROSCOPY TR-669

DEEP ULTRAVIOLET JA-5544

DEFENSE SWITCHED NETWORK TR-681

DEFENSE SYSTEMS TR-677

DEFLECTORS JA-5617

DEGRADATION MS-6402

DENSE TARGET ENVIRONMENT JA-5297, MS-6634

DENSITY DIGITAL INTERFACE TR-676 JA-5465 **DEPOSITION DIGITAL PROCESSING** JA-5534, MS-6564 MS-6412 **DIGITAL RADIO DESIGN** TR-667, MS-6543 MS-6463 **DETECTION** DIGITAL SIGNAL PROCESSING TR-634 TR-712, JA-5526, MS-6375, MS-6665 DIGITAL SPEECH DEVELOPMENT JA-5551 TR-683 **DEVICE FABRICATION** DIGITAL VOICE COMMUNICATION JA-5549, MS-6646 TR-671, JA-5488 **DIODE LASERS** DFT (SEE DISCRETE FOURIER JA-5587, JA-5601, JA-5607, JA-5618, TRANSFORM) JA-5627, MS-6472, MS-6536, MS-6540, DIAGNOSTIC RHYME TESTING MS-6556, MS-6647, MS-6652, MS-6674 TR-676 DIRECT DETECTION **DIAGRAMMATIC DENSITY MATRIX** MS-6277 **PERTURBATION DIRECT DETECTORS** JA-5502 MS-5929, MS-6187A DIAL (SEE DIFFERENTIAL ABSORPTION LASER RADAR) **DIRECT WRITING** JA-5571, MS-6529 DIAMOND-LIKE CARBON COATING **DIRECT-WRITE LASER PROCESSING** MS-5899A JA-5489, JA-5557, MS-6394, MS-6402 DIELECTRIC LENS ANTENNA **DISCRETE BANDS** JA-5476 TR-669 **DIELECTRICS** DISCRETE FOURIER TRANSFORM JA-5468 TR-689, TR-707, MS-6412, MS-6420 **DIFFERENTIAL ABSORPTION LASER DISLOCATIONS RADAR** JA-5616 JA-5623, MS-6456 **DIGITAL COMMUNICATIONS** DISPLACED PHASE CENTER ANTENNA JA-5454 MS-6335 **DIGITAL FILTERS DISTORTION** JA-5526, MS-6590 MS-6414

DIGITAL INTEGRATED CIRCUITS

TR-685

DISTRIBUTED ESTIMATION THEORY

MS-6463

Subject Index	Su	bie	et I	ndex
---------------	----	-----	------	------

DISTRIBUTED SENSOR NETWORK MS-6463

DLTS (SEE DEEP LEVEL TRANSIENT SPECTROSCOPY)

DONORS JA-5562, JA-5654

DOPED CRYSTAL JA-5623

DOPING JA-5465, JA-5539

DOPPLER FILTERING MS-6412

DOPPLER FREQUENCY JA-5586

DOPPLER MEASUREMENTS JA-5586

DOPPLER RADAR MS-5931, MS-6412

DOUBLE HETEROSTRUCTURE JA-5618, MS-6652, MS-6674

DPCA (SEE DISPLACED PHASE CENTER ANTENNA)

DRT (SEE DIAGNOSTIC RHYME TESTING)

DRY ETCHING JA-5549, MS-6307A, MS-6411

DSN (SEE DISTRIBUTED SENSOR NETWORK)

DTW (SEE DYNAMIC TIME WARPING)

DUAL FREQUENCY JA-5525

DUAL GATE MS-6449A

DYE LASERS JA-5627 DYNAMIC TIME WARPING MS-6413

E REGION TR-709

E-BEAM EVAPORATION JA-5599

E-PLANE JA-5525

EARTH APPROACHING ASTEROID JA-5452

EDGE BONDED TRANSDUCERS MS-6379

EFFECTIVE MASS THEORY JA-5623

EFIE (SEE ELECTRIC FIELD INTEGRAL EQUATION)

EHF (SEE EXTREMELY HIGH FREQUENCY)

ELASTIC CONVOLVER MS-6385

ELECTRIC FIELD INTEGRAL EQUATION MS-6504, MS-6548

ELECTRIC FIELDS JA-5554

ELECTROABSORPTION JA-5564, MS-6438

ELECTROACOUSTICS MS-6378

ELECTROMAGNETIC EFFECTS MS-6382

ELECTROMAGNETIC SCATTERING TR-662, MS-6548

ELECTROMAGNETIC WAVES TR-709

ELECTRON BEAMS JA-5537, JA-5539, MS-6541

ELECTRON CAPTURE MS-6589

ELECTRON DEVICES JA-5465

ELECTRON DIFFRACTION JA-5560, JA-5597

ELECTRON EMISSION MS-6589

ELECTRON IRRADIATION JA-5612

ELECTRON MICROSCOPY JA-5532

ELECTRON NUMBER FLUCTUATIONS
JA-5587

ELECTRONIC ABSORPTION SPECTRA MS-6527

ELECTRONIC PROPERTIES TR-669

ELECTROOPTIC SWITCHES JA-5616

ELECTROOPTICAL TR-634, JA-5522

ELECTROOPTICAL DEVICES JA-5522, JA-5532, JA-5570, JA-5635, MS-6523, MS-6553

ELECTROOPTICS JA-5606

ELECTROSTATICS TR-688

ELLIPSO METRIC STUDIES MS-6397

ELLIPTIC JA-5617

ENERGY TR-634

ENERGY GAP JA-5528, JA-5569

ENERGY STORAGE TR-684

ENHANCEMENT MS-6382

EPITAXIAL GROWTH TR-669, JA-5570, MS-6334

EPITAXIAL LAYER JA-5546, JA-5560, JA-5652

EPROM JA-5537

EQUATIONS TR-684, TR-694, JA-5543

ERROR ANALYSIS MS-6420

ERROR PROBABILITY TR-654

ERRORS TR-686

ESTIMATION TECHNIQUES TR-654

ESTIMATION THEORY TR-705

ETALONS JA-5616

ETCHING JA-5514, JA-5549

EXCIMER LASER JA-5544, JA-5653

EXCITED STATES
JA-5603

EXCITON STATES JA-5543

EXECUTIVE ROUTINES JA-5487

EXHAUSTIVE BIT PATTERNS TR-685

EXPERIMENTAL DEVICE JA-5575

EXPERIMENTAL SYSTEM JA-5580

EXTRAPOLATION MS-6420

EXTREMELY HIGH FREQUENCY JA-5476, JA-5593, JA-5646, MS-5903, MS-6473

F-15 TR-683

FABRICATION JA-5539, JA-5545, JA-5561, JA-5599, JA-5611, JA-5612, JA-5618, MS-6433, MS-6456, MS-6543, MS-6640, MS-6674

FABRY-PEROT CAVITY LASER MS-6329A

FACEMASK MS-6414

FADING TR-671

FAR FIELD MS-6543

FAST FOURIER TRANSFORM MS-6412

FATIGUE TR-684 FEDERAL AVIATION ADMINISTRATION JA-5580, MS-6525

FEED HORN JA-5525

FEEDBACK TR-685

FERRITES TR-688

FET (SEE FIELD EFFECT TRANSISTORS)

FIBER OPTICS JA-5545, JA-5635, MS-6538

FIBER REINFORCEMENT TR-684

FIELD EFFECT TRANSISTORS
JA-5465, JA-5656, MS-6347, MS-6470

FIELD INTENSITY JA-5595

FIGHTERS MS-6414

FILM MS-6409

FILM DEPOSITION MS-6397

FILTER BANK TR-707

FILTER DESIGN JA-5297

FILTERING TR-694, MS-6431

FILTERS TR-691, MS-6233A

FIREPOND MS-5931

FIXED OBJECT JA-5452

FIXED-ORDER COMPENSATION MS-6311

FLICKER NOISE MS-6635

FLIGHT TESTING JA-5580, MS-6525

FLOATING GATE FET JA-5537

FLUCTUATIONS MS-6536

FLUORIDES MS-6380

FLYWHEEL FORMULAS TR-684

FLYWHEELS TR-684

FM TRANSCEIVER TR-676

FOCUS SENSOR JA-5399

FOCUSED BEAM JA-5399

FOUCAULT TEST JA-5399

FOURIER TRANSFORM JA-5564, MS-6115, MS-6420, MS-6438

FREE ELECTRONS
JA-5543

FREQUENCY DOUBLING MS-6544

FREQUENCY ESTIMATOR TR-689

FREQUENCY MODULATION MS-6289

FREQUENCY SHIFTING MS-6422, MS-6538

FSK

MS-6422, MS-6447, MS-6472

GaAs (SEE GALLIUM ARSENIDE)

GAIN

JA-5627, MS-6449A

GaInAsP/InP LASERS JA-5545, JA-5551, MS-6562

GALLIUM ALUMINUM ARSENIDE JA-5546, JA-5553, JA-5587, MS-6329A, MS-6444, MS-6450, MS-6472, MS-6536, MS-6562

GALLIUM ALUMINUM ARSENIDE LASERS JA-5547, JA-5627, MS-6497, MS-6517, MS-6523

GALLIUM ARSENIDE
TR-669, JA-5465, JA-5495, JA-5532,
JA-5543, JA-5549, JA-5560, JA-5561,
JA-5562, JA-5564, JA-5585, JA-5597,
JA-5599, JA-5637, JA-5644, MS-6307A,
MS-6329A, MS-6347, MS-6438,
MS-6449A, MS-6452, MS-6456,
MS-6470, MS-6544, MS-6553, MS-6628,
MS-6635, MS-6651, MS-6652

GALLIUM INDIUM ARSENIDE PHOSPHIDE JA-5514, JA-5590

GARNETS MS-6380

GAS PHASE PHOTOCHEMISTRY MS-6400

GAS PHASE PHOTOLYSIS MS-6524

GATE ARRAY JA-5571, MS-6402, MS-6564

GATE INSULATORS MS-6589

GAUSS METHOD JA-5602

GAUSS-GIBBS TR-618

GAUSSIAN NOISE TR-654

GAUSSIAN PROCESSES JA-5425

GAUSSIAN SIGNALS TR-654

GENERAL AVIATION JA-5580

GENERATION-RECOMBINATION NOISE MS-6635

GEOSYNCHRONOUS SATELLITES
JA-5476

GERMANIUM JA-5538, JA-5544, JA-5560, JA-5597, JA-5599, MS-6456, MS-6674

GERMANIUM/SILICON MS-6456

GLASS JA-5617

GLASS FIBERS TR-684

GLASSBLOWER JA-5617

GLOBAL POSITIONING JA-5580 GRAIN BOUNDARIES TR-669

GRAPHITE HEATERS
JA-5535, JA-5622, MS-6409

GRATINGS JA-5532, JA-5534, JA-5561, MS-6378

GREEN'S FUNCTION TR-709, JA-5554

GRIDS MS-6465

GROUND SURVEILLANCE MS-6447

GROUND-BASED TR-618, JA-5565

GROUND-TO-AIR JA-5586

GROUP III-V MS-6553

GROWTH JA-5468, JA-5597, JA-5623

GUIDED WAVE JA-5522, JA-5585, MS-6240, MS-6289, MS-6438, MS-6528, MS-6574

GUIDED WAVE OPTICS JA-5637, MS-6508, MS-6523, MS-6561

H-FIELD TR-709

HALIDES JA-5544

HALL EFFECT JA-5570

HETERODYNE DETECTION JA-5573, MS-5929, MS-6737

HETERODYNE LASER RADAR MS-6737

HETERODYNE RADIOMETRY JA-5542, JA-5573

HETERODYNE RECEPTION MS-6418

HETERODYNE SPECTROSCOPY JA-5607, JA-5608

HETEROSTRUCTURE JA-5543, MS-6651

HETEROSTRUCTURE LASERS
JA-5590

HgCdTe LASERS (SEE MERCURY CADMIUM TELLURIDE LASERS)

HIGH EFFICIENCY JA-5569, MS-6651

HIGH FREQUENCY TR-671, JA-5607, MS-6329A, MS-6635, MS-6640

HIGH GAIN JA-5476, JA-5593

HIGH POWER TR-688

HIGH POWER LASER MS-6542

HIGH REFLECTIVITY
JA-5553

HIGH RESOLUTION JA-5542

HIGH SPEED JA-5585, JA-5601, JA-5637, MS-6423, MS-6540, MS-6574, MS-6640, MS-6665

HISTORY JA-5551

HOLOGRAPHY MS-6378 HOMOMORPHIC FILTERING MS-6417

HORN ANTENNAS MS-6543

HYBRID JUNCTION MS-6418

HYSTERESIS TR-688

IEEE-488 STD BUS MS-5959

IMAGE CLASSIFICATION TR-705

IMAGE DEGRADATION MS-6417

IMAGE ENHANCEMENT
JA-5464

IMAGE PROCESSING TR-634, JA-5464

IMAGE SEGMENTATION TR-705

IMPEDANCE JA-5676, MS-6347

IMPEDANCE BOUNDARY CONDITIONS MS-6504, MS-6548

INDIUM GALLIUM ARSENIDE MS-6637

INDIUM PHOSPHIDE JA-5562, JA-5570, JA-5623, JA-5654, MS-6334, MS-6423, MS-6637

INFRARED DETECTORS MS-5929

INFRARED RADAR MS-5931

INFRARED REGION
JA-5550

INFRARED SPECTRUM JA-5468

INITIAL ORBIT JA-5602

IN-PHASE COMPONENTS JA-5526

INSTABILITY MS-6561

INSTRUMENTATION JA-5489

INTEGRAL EQUATIONS TR-709, MS-6504, MS-6548

INTEGRALS JA-5554

INTEGRATED CIRCUITS JA-5536, JA-5537, JA-5570, JA-5571, JA-5599, MS-6131A, MS-6409, MS-6519, MS-6541, MS-6564, MS-6640, MS-6665

INTEGRATED OPTICS JA-5429, JA-5514, MS-6289, MS-6543, MS-6562, MS-6574

INTEGRATION MS-6385

INTERCONNECTIONS
JA-5606, MS-6402, MS-6519

INTERFERENCE SUPPRESSORS MS-6335

INTERFEROMETERS
JA-5429, JA-5635, JA-5636, JA-5637,
MS-5264, MS-6433, MS-6553

INTERFEROMETRY JA-5514, MS-6240, MS-6289, MS-6528

INTERNETWORK JA-5567 INTERPOLATION TR-689

INTERSATELLITE LINK TR-667, MS-6472

ION BEAM ETCHED JA-5549, MS-6307A

ION BEAMS MS-6465

ION IMPLANTATION
JA-5536, JA-5570, JA-5582

IONIZATION JA-5623

ITERATIVE ALGORITHMS MS-6634

ITERATIVE PROCESSING MS-6115, MS-6417

JTIDS SPEECH PROCESSING TR-683

K-BAND JA-5525

K-DISTRIBUTION JA-5565

Ka-BAND MS-6544

KALMAN FILTER TR-699, JA-5297

KEY DEVICE JA-5575

KINETIC PROCESSES MS-6524

KREMS TR-699

	Subject mack
KRONECKER DELTA JA-5425	LASER PROCESSING MS-6382
LANGMUIR-HINSHELWOOD	LASER PULSES JA-5644
MECHANISM JA-5584	LASER RADIATION JA-5653
LAPLACE-TAFF TR-618	LASER RESONATOR PARAMETERS JA-5489
LAPLACIAN INITIAL ORBIT DEFINITION SCHEME	LASER WRITING MS-6564
JA-5602 LASER ACTIVATED DEPOSITI	LASER-CHEMICAL MODIFICATION ON MS-6400A
JA-5539 LASER APPLICATIONS JA-5551, JA-5658, MS-6519, N	LASERS JA-5547, JA-5551, JA-5658, MS-6402, MS-6529 MS-6411, MS-6529, MS-6564
LASER BEAMS JA-5578, MS-6400	LATERAL EPITAXIAL GROWTH TR-669
LASER COMMUNICATIONS TR-667	LATERAL OVERGROWTH TR-669
LASER CRYSTALS MS-5264	LATTICES TR-688
LASER DIODES JA-5553, JA-5603, MS-6530	LAYERED DEFENSE SYSTEM TR-677
LASER DOPING JA-5489	LEAD TELLURIDE MS-6556
LASER ETCHING JA-5489, MS-6411	LEAD-SALT MS-6321
LASER FABRICATION MS-6411	LEAKAGE TR-677
LASER IRRADIATION MS-6397	LEAST MEAN SQUARE TR-691
LASER MATERIALS MS-6380	LEAST SQUARES MS-6431
LASER MICROCHEMISTRY JA-5539, JA-5557, JA-5571, M MS-6564	LEC METHOD (SEE LIQUID ENCAPSU- IS-6394, LATED CZOCHRALSKI METHOD)

LENS ANTENNAS JA-5476

LIDAR JA-5551, MS-5929

LIGHT CLOUD COVER MS-6417

LIKELIHOOD FUNCTION TR-689

LIMP FLYWHEEL TR-684

LINCOLN BOOLEAN SYNTHESIZER MS-6131A

LINEAR PREDICTION TR-705, JA-5425, MS-6335, MS-6363

LINEAR PREDICTIVE CODING JA-5356

LINEAR PREDICTIVE VOCODING TR-676, MS-6413

LINEWIDTH
JA-5553, JA-5587, MS-6321, MS-6394

LINEWIDTH BROADENING MS-6394, MS-6536

LIQUID ENCAPSULATED CZOCHRALSKI METHOD JA-5562, JA-5623, JA-5654

LIQUID PHASE EPITAXY JA-5514, JA-5545, JA-5654

LITHIUM COMPOUNDS MS-6378

LITHIUM NIOBATE
JA-5429, JA-5522, JA-5559, JA-5585,
JA-5595, JA-5600, JA-5614, JA-5635,
JA-5636, JA-5637, MS-6240, MS-6277,
MS-6289, MS-6378, MS-6385, MS-6433,
MS-6508, MS-6523, MS-6528, MS-6543,
MS-6561

LITHIUM TANTALATE MS-6378

LITHIUM TITANIUM FERRITE TR-688

LOCAL ACCESS NETWORK
JA-5488

LOCAL OSCILLATOR JA-5542, JA-5573, MS-6418

LORENTZ TRANSFORMATIONS MS-6422

LORENTZIAN PROFILE MS-6321, MS-6472

LOW COST JA-5580

LOW ELEVATION TR-686

LOW FREQUENCY MS-6635

LOW INTENSITY MS-6524

LOW RATE VOCODER TR-676

LOW THRESHOLD JA-5590

LOW VISION JA-5464

LOW-GRAZING ANGLE JA-5565

LOW-LOSS JA-5514, JA-5614

LOW-PRESSURE CHEMICAL VAPOR DEPOSITION JA-5535, JA-5622

LPC (SEE LINEAR PREDICTIVE CODING)

LPC-10 TR-676

LPCVD (SEE LOW-PRESSURE CHEMICAL VAPOR DEPOSITION)

LUMINESCENCE JA-5543

LUMPED CIRCUIT CHARACTERIZATION MS-6528

MACH-ZEHNDER JA-5522, JA-5635, MS-6240, MS-6289, MS-6433, MS-6553, MS-6561

MACPITTS MS-6131A

MAGNESIUM FLUORIDE MS-6542

MAGNETIC FIELD INTEGRAL EQUATION
MS-6504, MS-6548

MAGNETIC FIELDS JA-5543

MAGNITUDE TR-707, MS-6115, MS-6394, MS-6475

MASKED ION BEAM LITHOGRAPHY MS-6465

MASKING MS-6465

MASKLESS ETCHING JA-5532

MASS SPECTROSCOPY JA-5562

MASS-TRANSPORT JA-5545, JA-5590, MS-6394, MS-6562

MATCHED FILTERS MS-6335

MATHEMATICAL ANALYSIS JA-5602

MATHEMATICAL MODELS TR-699, JA-5575

MATRIX-MATRIX PRODUCT MS-6445

MAXIMUM A PRIORI PROBABILITY ESTIMATION TR-654

MAXIMUM LIKELIHOOD TECHNIQUE TR-689, TR-694, TR-705, JA-5356, JA-5425, MS-6232, MS-6422, MS-6634

MBE (SEE MOLECULAR BEAM EPITAXY)

MDAC (SEE MULTIPLYING D/A CONVERTER)

MEAN SQUARE ERROR TR-654

MEDICAL RESEARCH TR-683

MELT GROWTH JA-5623

MERCURY CADMIUM TELLURIDE LASERS MS-6435

MESFETS JA-5599, JA-5656, MS-6449A, MS-6652, MS-6674

METAL SEMICONDUCTOR JA-5656

METHYLMETHACRYLATE MS-6400

MFIE (SEE MAGNETIC FIELD INTEGRAL EQUATION)

MGS (SEE MONOLITHIC GALLIUM ARSENIDE SILICON)

MIBL (SEE MASKED ION BEAM LITHOGRAPHY)

MICROCHEMISTRY JA-5539, JA-5557, JA-5658

MICROCOMPUTER TR-712, JA-5487

MICROELECTRONICS MS-6529

MICROFABRICATION JA-5658, MS-6233A

MICROMETER-SIZED CHEMICAL PROCESSES MS-6411

MICROPHONES TR-691

MICROWAVE DEVICES JA-5570

MICROWAVE OSCILLATOR MS-6632

MICROWAVE POWER TR-688

MICROWAVE RADIATION JA-5562, JA-5644

MILITARY COMMUNICATIONS TR-681

MILITARY SATELLITE COMMUNI-CATION (SEE MILSATCOM)

MILSATCOM MS-5903

MIRRORS JA-5590, MS-6562

MIRV JA-5602

MIXED-MEDIA ROUTING TR-681

MIXERS MS-6590

MLT (SEE MAXIMUM LIKELIHOOD TECHNIQUE)

MMIC (SEE MONOLITHIC MICROWAVE INTEGRATED CIRCUIT)

MMS (SEE MULTISTATIC MEASURE-MENT SYSTEM)

MOBILE TERMINALS MS-6473

MODE C MS-6526

MODE LOCKED JA-5550, JA-5644, MS-6542

MODE S MS-6526

MODE S EXPERIMENTAL FACILITY (SEE MODSEF)

MODE SPLITTER
JA-5559

MODEMS TR-712

MODSEF MS-6525

MODULATION JA-5607, JA-5637

MODULATORS JA-5514, JA-5522, JA-5635, JA-5636, MS-6240, MS-6289, MS-6528, MS-6553, MS-6561

MODULES JA-5569, MS-6385

MOLECULAR ASTRONOMY JA-5573

MOLECULAR BEAM EPITAXY JA-5560, JA-5597, JA-5656, MS-6397

MONOLITHIC CIRCUITS JA-5536, JA-5597, JA-5599, MS-6544

MONOLITHIC GALLIUM ARSENIDE SILICON JA-5599, JA-5656, MS-6674

MONOLITHIC MICROWAVE INTEGRATED CIRCUIT MS-6449A

MONOLITHIC STRUCTURES JA-5618, JA-5637, MS-6456

MONOPOLE MS-6461

MONOTONE SPFECH TR-680

MONTE CARLO TR-654

MOON JA-5602

MORPHOLOGY JA-5514

MOS

JA-5606

MOS IMPLEMENTATION SERVICE MS-6131A

MOSFETS
JA-5489, JA-5612, MS-6409, MS-6483

MOSIS (SEE MOS IMPLEMENTATION SERVICE)

MOVING PLATFORM RADAR MS-6335

MULTICHANNEL COMMUNICATION MS-6335

MULTIPLE BEAM ANTENNA JA-5476 MULTIPLE BEAMS JA-5593

MULTIPLE BRANCHING CIRCUITS
JA-5614

MULTIPLE RATE PROCESSOR TR-712

MULTIPLE TARGETS MS-6634

MULTIPLE WAVEGUIDES MS-6530

MULTIPLEXING
JA-5488

MULTIPLYING D/A CONVERTER MS-6412, MS-6445

MULTISTATIC MEASUREMENT SYSTEM TR-699

MUTUAL COUPLING MS-6461

N-COUPLED OPTICAL WAVEGUIDE JA-5603

N-TYPE SEMICONDUCTORS JA-5582

NARROW BAND JA-5356

NARROW-BAND NOISE TR-683

NAVY COMMUNICATIONS JA-5646

NEAR INFRARED JA-5547, JA-5627

NEGATIVE RESISTANCE MS-6329A

NEW TECHNOLOGY MS-6375

NICKEL MAGNESIUM FLUORIDE LASER JA-5550, MS-5264, MS-6542

NICKEL MAGNESIUM OXIDE LASER MS-5264

NITRIDED OXIDE MS-6589

NITRIDES JA-5468

NODES JA-5567, MS-6463

NOISE TR-689, TR-691, MS-6420, MS-6431, MS-6635

NOISE CANCELLATION MS-6414

NOISE MEASUREMENT MS-6418, MS-6422

NOISE REDUCTION TR-691

NONLINEAR ESTIMATION TR-654

NONLINEAR FILTER TR-654

NONLINEAR OPTICS JA-5502

NONLINEAR PROCESS JA-5502

NONLINEAR SYSTEMS TR-694

NONRECIPROCAL JA-5539

NONVOLATILE SWITCHES JA-5537

NUCLEATION JA-5656, MS-6400A

OBJECT DETECTION TR-705

OBSERVATION NOISE MS-6311

OFFSET CASSEGRAIN ANTENNA TR-662

OFFSET FREQUENCY JA-5525

OMCVD (SEE ORGANOMETALLIC CHEMICAL VAPOR DEPOSITION)

OPEN LOOP JA-5613

OPTICAL ANALYSIS MS-6646

OPTICAL CIRCUITS MS-6240, MS-6289

OPTICAL COMMUNICATION TR-667, JA-5553, JA-5601, MS-6187A, MS-6198A, MS-6418, MS-6497, MS-6517, MS-6540, MS-6637, MS-6647

OPTICAL DEVICES MS-6375, MS-6508

OPTICAL EFFECTS JA-5636, MS-6632

OPTICAL FIBER COMMUNICATIONS MS-6647

OPTICAL FREQUENCIES MS-6538

OPTICAL HETERODYNE JA-5607, MS-6538, MS-6737

OPTICAL IMAGING JA-5544

	S
OPTICAL MEASUREMENTS JA-5532	OSCILLATIONS MS-5264
OPTICAL PROCESSING JA-5502, JA-5564	OSCILLATORS JA-5676
OPTICAL PROPAGATION MS-6358	OUTBOARD PROCESSORS TR-681
OPTICAL TECHNIQUES JA-5606, JA-5644, MS-6394	OUTPUT POWER MS-6556
OPTICAL TESTING JA-5399	OVERVIEW JA-5454
OPTICAL TRANSMISSION JA-5595, JA-5614	OXIDATION JA-5495, MS-6382
OPTICAL WAVEFRONTS MS-6508	OXYGEN JA-5622, MS-6409
OPTICAL WAVEGUIDES JA-5429, JA-5514, JA-5595, JA-5600, MS-6433, MS-6508	P-TYPE SEMICONDUCTORS JA-5582
OPTICALLY PUMPED LASERS JA-5573	PACKET COMMUNICATIONS JA-5454, MS-6463
OPTICS TR-662, JA-5468, MS-6115	PACKET NETWORKS JA-5488, JA-5567
OPTIMAL DESIGN JA-5528	PACKET RADIO MS-6463
OPTIMAL SEARCHES JA-5452	PACKET SPEECH JA-5488
OPTIMUM ALLOCATION TR-677	PACKET SWITCHING JA-5454
OPTOELECTRONIC SWITCH JA-5644, MS-6423, MS-6574	PARALLEL PROCESSORS MS-6445
ORBIT DETERMINATION TR-618, JA-5602	PARALLELISM TR-705
ORGANOMETALLIC CHEMICAL VAPOR DEPOSITION JA-5546, MS-6444, MS-6628	PARAMETER ESTIMATION TR-694
ORGANOMETALLICS MS-6397	PARAMETERS TR-694, JA-5575

PASSIVE CHANNEL WAVEGUIDE JA-5559

PASSIVE OPTICAL SENSOR TR-686, MS-6634

PATTERNED GROWTH JA-5578, MS-6400A

PBT (SEE PERMEABLE BASED TRANSISTOR)

PERCEPTION TR-680, TR-707

PERFORMANCE JA-5575, MS-6187A

PERIODIC PROCESSES JA-5356

PERIODIC STRUCTURE MS-6382

PERMEABLE BASED TRANSISTOR JA-5534, JA-5561, JA-5575, MS-6628, MS-6635, MS-6640

PEROVSKITES MS-6380

PHASE MS-5959, MS-6590

PHASE CONTROL MS-6449A

PHASE DETECTION JA-5399

PHASE DISTORTION MS-6358

PHASE ERROR JA-5476

PHASE NOISE MS-6321

PHASE SHIFTERS MS-6347, MS-6449A PHASED ARRAY ANTENNA MS-6461

PHOTOACOUSTIC SPECTROSCOPY MS-6379

PHOTOACOUSTIC TECHNIQUES MS-6379

PHOTOCONDUCTORS MS-5929

PHOTODEPOSITION JA-5489, JA-5571, JA-5584, MS-6400, MS-6400A, MS-6524

PHOTODETECTORS JA-5399, MS-6637

PHOTODIODES MS-5929, MS-6435

PHOTOELECTRON JA-5574

PHOTOELECTRON SPECTROSCOPY
JA-5700

PHOTOLUMINESCENCE JA-5654

PHOTOLYSIS MS-6524

PHOTOMIXERS MS-6435

PHOTONUCLEATION JA-5578, MS-6400A

PHOTOREACTION JA-5584

PHOTOREFRACTIVE EFFECTS
JA-5636

PHOTOREFRACTIVE TECHNIQUES MS-6561

PHOTOVOLTAIC JA-5495

PHOTOVOLTAIC ARRAY JA-5613

PHYSICAL OPTICS TR-662

PHYSICAL PROPERTIES JA-5538

PICOSECOND JA-5429, JA-5627, MS-6240

PIEZOELECTRICS
JA-5465

PILOT MS-6414, MS-6525

PIN DIODES MS-5929

PITCH DISCRIMINATION TR-680

PIXELS TR-634

PLANAR ARRAYS MS-6416, MS-6461

PLANAR DIODES MS-6544

PLANETS JA-5586

PLASMAS JA-5495

PLATFORMS MS-6335

PMMA (SEE POLYMETHYLMETHA-CRYLATE)

POINT IMAGE JA-5399

POINT SOURCE TR-634 POINT TARGET TR-634

POINTING ERROR TR-701

POINTING SYSTEM JA-5613

POISSON PROCESSES JA-5565

POLYCRYSTALLINE JA-5611

POLYGRID TR-681

POLYMETHYLMETHACRYLATE JA-5489, JA-5561

POLYSILICON JA-5620, MS-6402, MS-6483, MS-6564

POWER DROPOUTS MS-6497

POWER SPECTRUM TR-707

PREDICTION ERROR TR-694

PRENUCLEATION MS-6400A

PRESSURE INDUCED JA-5502

PRESSURE TUNING JA-5608

PRESSURE VESSELS TR-684

PROBES MS-5899A

PROCESSORS TR-712

PROGRAMMABLE DEVICES JA-5537, MS-6321

PROTONS MS-6433

PROXIMITY PRINTING MS-6465

PULSE DOPPLER MS-6412

PULSE POSITION MODULATION MS-6187A

PULSE REPETITION FREQUENCY JA-5644, MS-6445

PULSE RESPONSE MS-6435

PULSE TRAIN TR-680

PULSED DYE LASER BEAM MS-6379

PULSED RADAR MS-6445

PYROLYSIS MS-6400

Q-ARY MS-6187A

Q-BAND JA-5525

Q-SWITCH JA-5550, JA-5601, JA-5616, MS-6277, MS-6540, MS-6647

Q-SWITCHED OPERATION JA-5601, MS-6540

QUADRATURE COMPONENTS JA-5526 QUANTUM EFFECTS MS-6536

QUANTUM EFFICIENCY JA-5546, MS-6456

QUANTUM WELLS JA-5543, JA-5676, MS-6329A, MS-6556, MS-6632

QUARTZ JA-5617, MS-6334

QUARTZ CRYSTALS MS-6277

QUASI OPTICAL MIXERS JA-5573

QUEUEING THEORY JA-5454

RADAR & OTHER DETECTION SYSTEMS MS-6447

RADAR IMAGING JA-5586

RADAR TARGETS MS-6504, MS-6548

RADIATION COUPLING JA-5600

RADIATION DAMAGE JA-5549

RADIO BROADCAST MS-6463

RADIO FREQUENCY JA-5526

RADIO FREQUENCY COMMUNICA-TIONS CIRCUITS MS-6590

RADIO FREQUENCY MIXER MS-6423

RAIN

MS-5903

RAMAN SCATTERING MS-5899A

RANDOM PROCESSES JA-5425

RANGE DOPPLER COUPLING JA-5586

RANGE ERROR TR-686

RANGE MEASUREMENTS JA-5586

RAPID THERMAL ANNEALING JA-5620, MS-6483

RARE GASES JA-5544

RATE LIMITS MS-6394

RE-ENTRY VEHICLES
JA-5554

REACTIVE ION ETCHING JA-5549

REACTOR MS-6334

REAL-TIME TR-701, JA-5487, MS-6475, MS-6665

REAL-TIME SYSTEM JA-5487

RECONFIGURATION MS-6564

RECONSTRUCTION MS-6475

RECRYSTALLIZATION JA-5582, JA-5612, JA-5652

RECURSIVE SEQUENCES JA-5356

RED (SEE REFLECTION ELECTRON DIFFRACTION)

REFLECTION ELECTRON DIFFRACTION JA-5560

REFLECTIVITY
JA-5553, MS-6115

REFLECTOR ANTENNA JA-5525, MS-6473

REFRACTION TR-701

REFRACTIVE INDEX MS-6115, MS-6397

RELAXATION TR-688, MS-5264

REMOTE SENSING MS-5931

RESIDUAL DONOR JA-5562

RESOLUTION MS-6232, MS-6465

RESONANCE JA-5502

RESONANT TUNNELING MS-6329A, MS-6632

RESONATORS JA-5676

RESTRUCTURABLE VLSI (SEE RVLSI)

RICCATI EQUATION JA-5297

RIPPLE MS-6382, MS-6447

RNAV

JA-5580 ROTARY-TABLE

MS-6334

ROTATIONAL LINES

JA-5542

ROTORS

TR-684

ROUTING

TR-681, JA-5454

RS-449

TR-676

RTA (SEE RAPID THERMAL

ANNEALING)

RUTILE

MS-6380

RVLSI

MS-6413, MS-6665

S-PARAMETERS

MS-5959

SAMPLE AND HOLD

MS-6423

SAMPLING

JA-5526, MS-6590

SATELLITE COMMUNICATIONS

JA-5593, MS-6473

SATELLITE CROSSLINKS

TR-667

SATELLITE IDENTIFICATION

MS-5931

SATELLITE LINKS

MS-5903

SATELLITE NETWORK (SEE SATNET)

SATELLITE TERMINALS

JA-5525

SATELLITE TRACKING

MS-5931

SATNET

JA-5488, JA-5567

SATURATION

JA-5608

SCAN/SET

TR-685

SCATTERING

TR-662, TR-709

SCHAWLOW-TOWNES FORMULA

JA-5553, MS-6321

SCHOTTKY BARRIERS

JA-5575

SCHOTTKY DIODE

JA-5542, JA-5573, MS-6307A

SEARCH THEORY

JA-5452

SECONDARY ION MASS

SPECTROMETRY

JA-5622, MS-6409

SEGMENTATION

MS-6449A

SELENIUM

JA-5544, JA-5570

SELF-ALIGNED DUAL-GRATING

JA-5561

SEMI-INSULATION

MS-6637

SEMICONDUCTING COMPONENTS

JA-5538

SEMICONDUCTOR DEVICES

JA-5575, MS-6646

SEMICONDUCTOR DIODE LASERS JA-5547, JA-5587, MS-6472

SEMICONDUCTOR JUNCTION LASER
JA-5582

SEMICONDUCTOR LASERS
JA-5429, JA-5551, JA-5607, MS-6418,
MS-6422, MS-6497, MS-6517, MS-6737

SEMICONDUCTORS JA-5465, JA-5489, JA-5495, JA-5554, JA-5562, MS-6334, MS-6553

SENSOR ARRAY MS-6416

SHALLOW-HOMOJUNCTION CELLS JA-5495, JA-5546, MS-6444, MS-6452, MS-6456, MS-6651

SHIFT REGISTERS TR-685

SHORT-TIME FOURIER TRANSFORM TR-707

SIGNAL PROCESSING JA-5429, JA-5564, JA-5585, JA-5606, JA-5637, MS-6233A, MS-6289, MS-6375, MS-6378, MS-6412, MS-6423, MS-6438, MS-6574

SIGNAL PROCESSOR MS-6385

SIGNAL RECONSTRUCTION MS-6420

SIGNAL-TO-NOISE RATIO TR-671, MS-6335, MS-6431

SIGNAL-TO-NOISE RATIO CALCULATION TR-634

SIGNALS TR-691

SIGNATURE GENERATION TR-685 SILICIDES MS-6483

SILICON

JA-5489, JA-5534, JA-5539, JA-5549, JA-5562, JA-5570, JA-5582, JA-5585, JA-5656, MS-6382, MS-6456, MS-6523, MS-6640

SILICON BOLOMETER JA-5536

SILICON DIOXIDE JA-5468, JA-5700, MS-6589

SILICON FILMS JA-5527, JA-5535, JA-5612, JA-5622, MS-5899A

SILICON OXYNITRIDE JA-5535, JA-5574, JA-5612, JA-5700

SILICON SUBSTRATES
JA-5560, JA-5597, JA-5612, JA-5653,
JA-5656, MS-6652, MS-6665, MS-6674

SILICON WAFER JA-5620

SILICON-ON-INSULATOR JA-5535, JA-5612, JA-5622, JA-5652, MS-6409

SILVER MS-6382

SIMS (SEE SECONDARY ION MASS SPECTROMETRY)

SIMULATION TR-689, MS-6445

SINGLE CRYSTAL FILMS JA-5536

SINGLE CRYSTALS JA-5597

SINGLE-JUNCTION CELLS JA-5569, JA-5611, MS-6674

SINGULAR INTEGRAL JA-5554

SINGULAR VALUE DECOMPOSITION MS-6420

SINUSOIDS TR-689, MS-6475

SNR (SEE SIGNAL-TO-NOISE RATIO)

SOLAR CELLS JA-5546, JA-5569, JA-5611, MS-6444, MS-6450, MS-6452, MS-6456, MS-6674

SOLAR CLOCK JA-5495

SOLID STATE LASERS JA-5551, MS-6380

SPACE APPLICATIONS MS-6198A, MS-6450

SPACE COMMUNICATIONS MS-6198A

SPACE OBJECTS JA-5586

SPATIAL ACQUISITION TR-667, MS-6198A, MS-6737

SPATIAL ALGORITHMS MS-6198A

SPATIAL LIGHT MODULATION JA-5564, MS-6438

SPATIAL RESOLUTION JA-5476, JA-5539, JA-5557, MS-5899A, MS-6394

SPECKLE MS-6232

SPECKLE IMAGE MS-6232

SPECTRAL ANALYSIS JA-5587, MS-6431, MS-6438 SPECTRAL COMPRESSION JA-5569

SPECTRAL DENSITY MS-6417

SPECTRAL ESTIMATION TR-654, JA-5356, JA-5425

SPECTRAL LINES JA-5543

SPECTRAL MAGNITUDE MS-6475

SPECTRAL SPLITTING JA-5569

SPECTRAL STUDIES JA-5547

SPECTROGRAM TR-707

SPECTROSCOPY JA-5574, JA-5654, MS-6379

SPEECH MS-6414, MS-6475

SPEECH ANALYSIS/SYNTHESIZER SYSTEM TR-707

SPEECH CODING JA-5356

SPEECH COMMUNICATIONS JA-5488

SPEECH COMPRESSION TR-712

SPEECH ENHANCEMENT TR-691

SPEECH PROCESSING TR-680

SPEECH PROCESSOR TR-712

SPEECH RECOGNITION TR-671, TR-707, MS-6413

SPEECH WAVEFORM MS-6475

SPICE (LINCOLN COMPUTER PROGRAM)
MS-6131A

SPLITTING RATIO JA-5559, JA-5614

SPOT BEAM ANTENNA JA-5525

SPREAD SPECTRUM MS-6385

STABILITY TR-684, MS-6447

STATE ESTIMATION JA-5297

STATIC INDUCTION TRANSISTOR MS-6640

STATISTICAL PROCESSES TR-705

STATISTICAL VARIATION TR-686

STENCIL MS-6465

STFT (SEE SHORT-TIME FOURIER TRANSFORM)

STOCHASTIC MODEL TR-705

STOCHASTIC PROCESSES JA-5502, MS-6417

STRIATIONS JA-5623

STRIP HEATER
JA-5535, JA-5622, MS-6409

SUB-BOUNDARIES

JA-5535, JA-5622, MS-6409

SUBMARINE COMMUNICATIONS
JA-5646

SUBMICROMETER PATTERNING TECHNOLOGY JA-5557

SUBMICROMETER PROCESSING JA-5532, JA-5534, JA-5557

SUBMICROMETER STRUCTURES JA-5549

SUBMICROMETER TECHNOLOGY JA-5557

SUBREFLECTORS TR-662

SUBSONIC AIRCRAFT MS-6463

SUBSTRATES MS-6334

SULFIDES JA-5654

SULFUR JA-5562

SUPERCONDUCTIVE ANALOG SIGNAL PROCESSING DEVICES MS-6233A

SUPERCONDUCTORS MS-6375

SUPERCOOLING MS-6409

SUPERSONIC FLOW JA-5542

SURFACE ACOUSTIC WAVE JA-5465, MS-6277, MS-6375, MS-6378, MS-6379

SURFACE CHEMISTRY MS-6397, MS-6400

SURFACE MICROSTRUCTURES MS-6382

SURFACE PHOTOACOUSTIC WAVE SPECTROSCOPY MS-6277, MS-6379, MS-6527

SURFACE PROCESSING MS-6524

SURFACE RADIATION MS-6397

SURFACE-PHASE PHOTOCHEMISTRY
MS-6400

SURFACES JA-5514, JA-5584, MS-6651

SURVEILLANCE MS-6526

SVD (SEE SINGULAR VALUE DECOMPOSITION)

SWEPT FREQUENCY JA-5635

SWITCHING TR-681

SWITCHING CIRCUITS MS-6347

SYNCHRONOUS GARBLE MS-6526

SYNTHESIZER MS-6321

SYSTOLIC ARRAYS TR-705, MS-6363, MS-6413

TAFF-HALL TR-618, JA-5602 TANDEM SOLAR CELLS JA-5569, MS-6444, MS-6452, MS-6456, MS-6674

TANDEM STRUCTURES
JA-5528

TANTALUM MS-6483

TANTALUM SILICIDE JA-5620

TAPPED DELAY LINES MS-6233A

TARGET DETECTION MS-6363

TARGET LOCATION TR-701

TARGET TRACKING JA-5297

TCAS II MS-6525, MS-6526

TEMPERATURE DEPENDENCE MS-6536

TEMPERATURE SENSORS MS-6240, MS-6289

TEMPLATE JA-5617

TERMINAL DEFENSE TR-677

TERMINALS MS-6473

TERRAIN JA-5565, JA-5586

TEST & EVALUATION JA-5537

TEST FACILITIES TR-683

TEU (SEE TRAFFIC ALERT & COLLISION AVOIDANCE EXPERIMENTAL UNIT)

THERMAL ANNEALING
JA-5582, MS-6307A, MS-6483

THERMAL FIXING JA-5636, MS-6561

THERMAL NITRIDE JA-5574, JA-5700

THERMAL NOISE MS-6635

THICK FILMS JA-5468, JA-5527

THIN FILM GROWTH MS-6400A

THIN FILMS
MS-5899A, MS-6115, MS-6277,
MS-6379, MS-6400, MS-6527

THIN SURFACE FILMS MS-6277

THREE-DIMENSIONAL IMAGE MS-6232

THRESHOLDS JA-5590, MS-6526

THUNDERSTORMS MS-5903

TIBA (SEE TRIISOBUTYLALUMINUM)

TIME BANDWIDTH PRODUCTS MS-6385

TIME DOMAIN MS-6335

TIME INTERVAL COUNTER MS-5959

TIME-INTEGRATING MS-6438

TIN

JA-5538

TITANIUM

JA-5429, JA-5559, JA-5600, JA-5614, JA-5635, JA-5636, MS-6240, MS-6289, MS-6561

TITANIUM TETRACHLORIDE JA-5584, MS-6400

TITANIUM: LITHIUM NIOBATE JA-5600, MS-6433, MS-6528

TJS (SEE TRANSVERSE JUNCTION STRIPE)

TONE FREQUENCIES TR-680

TOPOGRAPHIC IMPERFECTIONS JA-5535

TRACK INITIATION MS-6634

TRACKING MS-6416, MS-6463, MS-6634

TRACKING FILTER
TR-699

TRACKING SYSTEMS JA-5613, MS-6737

TRADEX TR-699

TRAFFIC ALERT & COLLISION
AVOIDANCE EXPERIMENTAL UNIT
MS-6525

TRANSCONDUCTANCE
JA-5599

TRANSIENTS MS-6470

TRANSISTORS
JA-5465, JA-5575, JA-5599

TUNGSTEN

JA-5534, JA-5653

TUNGSTEN SILICIDES

MS-6640

TUNNELING TRANSITION METAL-DOPED LASER JA-5676 MS-5264 TWO-CELL TANDEM STRUCTURE TRANSMISSION ELECTRON JA-5611 **MICROSCOPY** JA-5534 TWO-DIMENSIONAL JA-5425, JA-5557 **TRANSMITTERS** MS-6447 TWO-DIMENSIONAL IMAGING MS-6363 TRANSPORTABLE MEASUREMENTS **RADAR** TWO-PHOTON PROCESS MS-5931 MS-6277, MS-6379 TRANSVERSAL FILTER TWTA MS-6447 MS-6233A TRANSVERSE ELECTRIC-TRANSVERSE **MAGNETIC MODE ULF (SEE ULTRA LOW FREQUENCY)** JA-5559, JA-5635, MS-6538 **ULTRA LOW FREQUENCY** TRANSVERSE JUNCTION STRIPE JA-5646, MS-6470 JA-5587, JA-5627 ULTRAVIOLET IRRADIATION TRAVELING WAVES MS-6397 JA-5635, MS-6528 **ULTRAVIOLET LASERS TRIISOBUTYLALUMINUM** JA-5489, JA-5584, MS-6400A, MS-6529 JA-5578 **ULTRAVIOLET RADIATION** TRIMETHYLALUMINUM JA-5578 JA-5584, MS-6400 **ULTRAVIOLET SPECTRA** TRISTATIC TRACKING FILTER JA-5571 TR-699 **UNSEEDING TRUNCATION** JA-5527 MS-6420 UPLINK COVERAGE MEASUREMENT JA-5593 TUNABLE DIODE LASER MS-6321 **USER GUIDE** TR-676 **TUNABLE LASER** JA-5550, MS-5264



VAPOR DEPOSITION

VAPOR PHASE EPITAXY

JA-5534, JA-5561, JA-5654

MS-6628

VAPOR PHASE REACTION MS-6334

VARACTORS MS-6544

VENUS JA-5573

VERY HIGH FREQUENCY MS-6470

VERY HIGH SPEED INTEGRATED CIRCUITS (SEE VHSIC)

VERY LARGE SCALE INTEGRATION (SEE VLSI)

VERY LOW FREQUENCY JA-5646

VHF (SEE VERY HIGH FREQUENCY)

VHSIC

MS-6375

VISIBLE LASERS MS-6529

VISUAL IMAGES JA-5464

VISUAL IMPAIRMENT JA-5464

VISUAL PERCEPTION JA-5464

VLF (SEE VERY LOW FREQUENCY)

VLSI

TR-685, JA-5489, JA-5571, JA-5574, JA-5606, JA-5620, MS-6483

VOCODED SPEECH TR-671, TR-680

VOCODER TR-680, TR-683, TR-707, TR-712

VOICE COMMUNICATIONS TR-671, JA-5567 VOICE TERMINAL TR-676

VOLTAGE JA-5676

W PHASE JA-5653

WAFER SCALE INTEGRATION MS-6413

WAFER WARPAGE JA-5535

WAFER-SCALE CIRCUITS
JA-5537, MS-6519, MS-6541, MS-6665

WAFERS JA-5535, JA-5545, JA-5574, JA-5582

WAVEFORM CODER MS-6475

WAVEFORMS JA-5526, MS-6232, MS-6590

WAVEGUIDE BENDS JA-5595, JA-5614

WAVEGUIDE LENS JA-5603

WAVEGUIDES JA-5559, JA-5600, JA-5636, MS-6240. MS-6433, MS-6530, MS-6543

WET ETCHING JA-5532

WHITE NOISE JA-5297, MS-6431

WIDE BAND JA-5585, MS-6233A

WIDE BANDWIDTH MS-6435

WIDE-BAND NETWORK JA-5567

WIDE-BAND PACKET NETWORK JA-5567

WIDE-BAND SIGNALS MS-6416

X-RAY DIFFRACTION MS-6483

X-RAY PHOTOEMISSION JA-5700

X-RAYS JA-5574 YAG LASERS MS-6277

YTTRIUM ALUMINUM GARNET MS-6277

ZERNIKE JA-5399

ZINC SULFIDE JA-5611

ZONE-MELTING RECRYSTALLIZATION JA-5527, JA-5535, JA-5612, JA-5622, JA-5652, MS-6409

UNCLASSIFIED

SECURITY CLASSIFICATION OF THIS PAGE (When Data Entered)

REPORT DOCUMEN	TATION PAGE	READ INSTRUCTIONS BEFORE COMPLETING FORM	
1. REPORT NUMBER ESD-TR-84-329	2. GOVT ACCESSION NO.	3. RECIPIENT'S CATALOG NUMBER	
4. TITLE (and Subtitle)	,, ,, ,, ,, ,, ,, ,, ,, ,, ,, ,, ,, ,, 	5. TYPE OF REPORT & PERIOD COVERED	
Unclassified Publications of Lincol	ln	Bibliography, 15 December 1983 to 31 December 1984	
Laboratory — Volume 10	•••		
		6. PERFORMING ORG. REPORT NUMBER	
7. AUTHOR(s)		B. CONTRACT OR GRANT NUMBER(s)	
Publications Office		F19628-85-C-0002	
9. PERFORMING ORGANIZATION NAME AND ADDRES Lincoln Laboratory, M.I.T.	S	10. PROGRAM ELEMENT, PROJECT, TASK AREA & WORK UNIT NUMBERS	
P.O. Box 73		None	
Lexington, MA 02173-0073			
11. CONTI JULING OFFICE NAME AND ADDRESS	E	12. REPORT DATE	
Air Force Systems Command, USA Andrews AFB	Г	31 December 1984	
Washington, DC 20331		13. NUMBER OF PAGES 86	
14 MONITORING AGENCY NAME & ADDRESS (if di)	ferent from Controlling Office)	15. SECURITY CLASS. (of this Report)	
·	, ,	Unclassified	
Electronic Systems Division Hanscom AFB, MA 01731		15a. DECLASSIFICATION DOWNGRADING SCHEDULE	
nanscom Arb, MA 01751		134. DECLASSIFICATION DUWNGRADING SCHEDULE	
Approved for public release; distribution unlimited. 17. DISTRIBUTION STATEMENT (of the abstract entered in Block 20, if different from Report) 18. SUPPLEMENTARY NOTES None			
19. KEY WORDS (Continue on reverse side if necessary and identify by block number)			
Bibliography			
20. ABSTRACT (Continue on reverse side if necessary and identify by block number)			
Volume 10 of Unclassifed Publications of Lincoln Laboratory lists reports published from 15 December 1983 to 31 December 1984, as well as updated information on earlier publications. Documents listed herein are generally no longer available from Lincoln Laboratory. Qualified Defense Technical Information Center (DTIC) users may obtain copies through normal DTIC channels. Others may purchase photocopies or microfiche from the U.S. Department of Commerce, National Technical Information Service, Springfield, Virginia 22151. When ordering, the 6-digit AD number should be cited.			

DD FORM

73 EDITION OF 1 NOV 85 IS OBSOLETE

UNCLASSIFIED